# NCSX

# **SPECIFICATION**

# **General Requirements Document (GRD)**

# NCSX-ASPEC-GRD-01

Draft D

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#### **Controlled Document**

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# **Record of Revisions**

5/5/2003 8/17/03	-	Initial issue <u>DRAFT A (WTR)</u> Updated Appendix A – Technical Data Sheet Added requirement for controlled access into the test cell between shots in Section 3.3.6.2.2 Added Section 3.2.1.5.3.8 to specify coil current measurement. Changed the test cell opening width from 18' to 17'6'' in Section 3.2.3.1.2. Added Section 3.2.3.1.3.2 to specify a maximum platform floor loading. Substituted the Field Line Mapping scenario for the Initial Ohmic scenario throughout. <u>DRAFT B (RTS/GHN)</u>
8/17/03		<ul> <li>Updated Appendix A – Technical Data Sheet</li> <li>Added requirement for controlled access into the test cell between shots in Section 3.3.6.2.2</li> <li>Added Section 3.2.1.5.3.8 to specify coil current measurement.</li> <li>Changed the test cell opening width from 18' to 17'6" in Section 3.2.3.1.2.</li> <li>Added Section 3.2.3.1.3.2 to specify a maximum platform floor loading.</li> <li>Substituted the Field Line Mapping scenario for the Initial Ohmic scenario throughout.</li> </ul>
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		throughout.
		Cleared numerous TBRs and TBDs
		Replaced "operating temperature" with "cryogenic temperature" to eliminate
		ambiguity introduced with room temperature operation.
		Added a pre-run temperature requirement for the coils in Section 3.2.1.2.1.3.
		Modified the base pressure requirement in Section 3.2.1.2.2.1.
		Modified the pumping speed requirement in Section 3.2.1.2.2.2 to reflect having only two pumps installed initially.
		Changed "elevated" to "capable of being elevated" in background discussion in
		Section 3.2.1.2.3.
		GDC was made a future upgrade in Sections 3.2.1.2.3.5 and 3.2.1.4.1.
		<u>DRAFT C (WTR)</u>
		Replaced lettered paragraphs with numbered paragraphs throughout for improved
		cross-referencing.
		Moved vacuum compatibility requirement from Section 3.2.1.2.2.1 to Section 3.3.1.2.
		Divided Section 3.3.2 into lower level requirements.
		Moved requirements in Section 3.3.6.2 under Section 3.3.6.1
		Substituted "first plasma and initial field line mapping" for "initial ohmic operation" throughout.
		Deleted reference to initial limiters in Sections 3.2.1.2.3 and 3.2.1.5.4. Made poloidal limiters an upgrade requirement in Section 3.2.1.5.4.1.
		Deleted requirement for maximum heating power during Initial Ohmic phase of operation in Section 3.2.1.5.4.2.
		Added discussion of room temperature operation in Section 3.2.1.2.1. Changed title
		of Section 3.2.1.2.1.1 to Timeline for Coil Cool-down to Cryogenic Temperature
		Inserted a Field Line Mapping Scenario and removed the Initial Ohmic Scenario in Section 3.2.1.5.3.3.1.2.
		Changed the 1.9T High Beta Scenario back to 2T in Section 3.2.1.5.3.3.1.6.
		Changed the requirement for initial operation of the electrical power and cryogenic
		systems from meeting the requirements of the Initial Ohmic Scenario to meeting the requirements of the First Plasma and Field Line Mapping Scenarios in Section 3.2.1.5.3.3.2.
		Changed the initial NB requirement from two beamlines to one beamline in Section
		3.2.1.5.6.1.1. Explicitly defined the initial diagnostic requirements in Section 3.2.1.5.8.2.
		<u>Draft D (WTR)</u> Updated TDS to reflect more conservative heat leakage and LN2 consumption.

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# 1 SCOPE

#### 1.1 Identification

This document, the National Compact Stellarator Experiment (NCSX) General Requirements Document (GRD), specifies the performance, design, documentation, and quality assurance requirements for the NCSX to be installed and operated at the Princeton Plasma Physics Laboratory (PPPL).

# 1.2 System Overview

The National Compact Stellarator Experiment (NCSX) will be a proof-of-principle scale facility for studying the physics of compact stellarators, an innovative fusion confinement concept. The facility will include the stellarator device and support systems. It will be constructed at the Princeton Plasma Physics Laboratory.

## 1.3 Document Overview

The GRD is a system specification. It is to be used as the basis for developing lower level (subsystem and component) technical specifications for the NCSX Project.

## 1.3.1 Relationship of System to Subsystem Requirements

The specification approach being used on NCSX provides for a clear distinction between system and subsystem requirements as well as between performance requirements and design constraints.

Performance requirements state what functions a system has to perform and how well that function has to be performed. Design constraints, on the other hand, are a set of limiting or boundary requirements that must be adhered to while allocating requirements or designing the system. They are drawn from externally imposed sources (e.g., statutory regulations, DOE Orders, and PPPL ES&H Directives) as well as from internally imposed sources a result of prior decisions, which limit subsequent design alternatives.

Within this system specification, Section 3.2.1 defines the performance requirements that apply to the system as a whole. Section 3.7 defines the allocation of the system performance requirements to specific subsystems. Those requirements will flow down to subsystem development (or "design-to") specifications, which are or will be documented as project documents (NCSX-BSPEC-WBS-...). There the subsystem performance requirements contained in Section 3.2.1 are generally drawn from the applicable subsystem allocations within Section 3.7 of this document. Additional performance requirements at the subsystem level may also be included for completeness. Similarly, the subsystem development specification will contain performance requirements allocated to specific major components of the subsystem.

The remainder of Section 3 of this specification is generally considered to consist of design constraints. As a rule, design constraints are not allocated to subsystems within Section 3.7. However, subsystem specific constraints may be interspersed with the system level design constraints if they are considered significant enough for inclusion within the system specification. Within the subsystem development specifications, design constraints for the subsystem, consist of derived system level constraints and other applicable constraints, will be documented.

#### **1.3.2** Incomplete and Tentative Requirements

Within this document, the term "to be determined" (**TBD**) applied to a missing or incomplete requirement means that additional effort (analysis, trade studies, etc.) is required before the requirement can be completed. The term "to be revised" (**TBR**) applied to a requirement means that a tentative requirement has been established but additional effort is needed to fully understand the cost/benefit implications, and thus the requirement is subject to change.

#### **2** APPLICABLE DOCUMENTS

The following documents of the exact issue shown form a part of this specification to the extent specified herein. In the event of a conflict, the contents of this specification shall be considered a superceding requirement.

# 2.1 Government Documents

DOE-STD-1020-2002, "Natural Phenomena Hazards Design and Evaluation Criteria for Department of Energy Facilities"

29CFR1910

DOE O 420.1

#### 2.2 PPPL Documents

PPPL ESHD-5008, "PPPL Environment, Safety, and Health Directives."

## 2.3 NCSX Documents

NCSX Work Breakdown Structure (WBS) Dictionaries (NCSX-WBS-wbs#), where wbs# is the WBS identifier

NCSX Vacuum Materials List (to be provided)

NCSX Structural and Cryogenic Design Criteria Document (to be provided)

NCSX Grounding Specification for Personnel and Equipment Safety (to be provided)

NCSX Test and Evaluation Plan (to be provided)

NCSX RAM Plan (to be provided)

# 2.4 Other Documents

TBD

#### **3** SYSTEM REQUIREMENTS

#### 3.1 System Definition

#### 3.1.1 General Description

The mission of the NCSX is to acquire the physics knowledge needed to evaluate compact stellarators as a fusion concept, and to advance the physics understanding of three-dimensional plasmas for fusion and basic science.

The NCSX device is a medium-scale (R=1.4 m), low aspect ratio ( $A\sim4$ ) stellarator-tokamak hybrid. It features modular coils, toroidal field (TF) coils, and poloidal field (PF) coils for plasma shaping and control. It also has a vacuum-tight vessel internal to the coils.

The NCSX facility will be sited at C-Site at the Princeton Plasma Physics Laboratory (PPPL). Some subsystems will be located at D-Site at PPPL. The stellarator will be situated in the former PBX-M/PLT Test Cell. This test cell will hereafter be referred to as the NCSX Test Cell.

#### 3.1.2 Major Item of Equipment (MIE) Project Scope

The NCSX MIE Project shall include all equipment required for first plasma and initial field line mapping, including the support subsystems required to support that equipment.

In addition, the NCSX MIE Project shall include equipment needed to support coil operation at cryogenic temperatures and the refurbishment and installation of equipment for 1.5 MW of neutral beam heating power.

This specification provides requirements for the MIE Project, including requirements to be able to accommodate certain equipment upgrades that may be needed in the future.

For equipment not in the MIE Project but required as a future upgrade, the effort required to assure that the equipment can be accommodated shall be included in the MIE Project.

#### 3.1.3 System Elements

All work required to execute the Project has been identified in the NCSX Project Work Breakdown Structure (WBS) Dictionary. A listing of Level 2 (1-digit) WBS elements is provided in Table 3-1.

WBS	
1	Stellarator Core Systems
2	Auxiliary Systems
3	Diagnostic Systems
4	Electrical Power Systems
5	Central Instrumentation and Control Systems
6	Facility Systems
7	Test Cell Preparation and Machine Assembly
8	Project Management and Integration
9	Preparations for Operations

Table 3-1 Level II Work	Breakdown Structure
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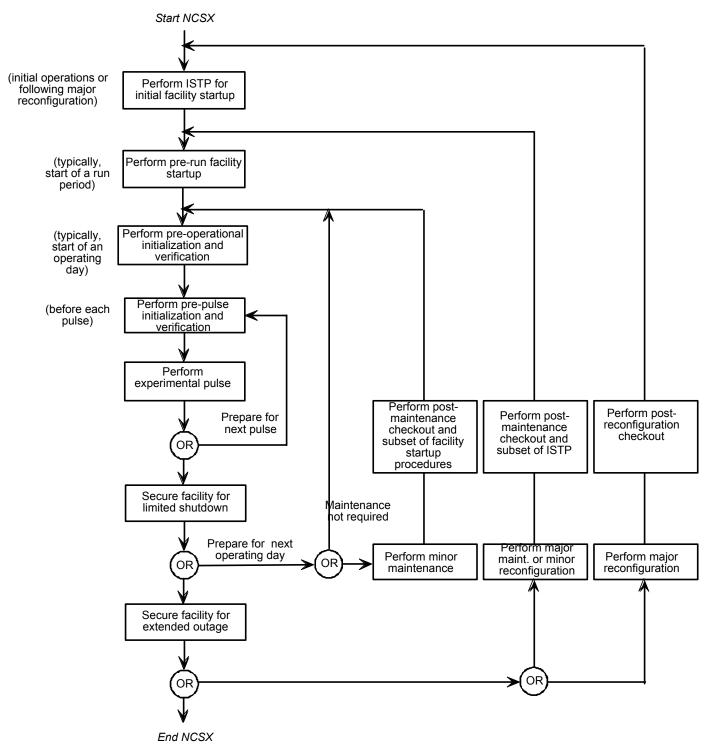


Figure 3-1 NCSX System Functional Flow Diagram

#### 3.1.4 System Functions

The top-level system functions for NCSX are detailed in Figure 3-1. This functional flow diagram provides the foundation for the scope of the requirements within Section 3.2 of this specification.

#### 3.2 Characteristics

## **3.2.1** Performance Characteristics

# 3.2.1.1 Initial Facility Startup

#### **Background**

Initial facility startup includes all activities required to verify safe operation of NCSX systems after their initial assembly and installation, or after a major facility reconfiguration, and before plasma operations. Initial facility startup activities would be performed prior to First Plasma and will include an Integrated System Test Program (ISTP) to verify that the system operates safely and as expected prior to plasma operation. For example, the ISTP will include verification of proper coil polarities and power supply connections. The ISTP will also include verification that, at First Plasma, the system demonstrates a level of system performance sufficient for the start of research operations, as specified in the Project Execution Plan. A subset of the ISTP will be conducted before the start of a run.

#### <u>Requirement</u>

The system shall provide the capability to perform a comprehensive integrated system test program, to verify, prior to plasma operation, that the system operates safely and as expected.

## 3.2.1.2 Pre-Run Facility Startup

#### **Background**

Pre-run facility startup includes all activities required to verify safe operation of the NCSX systems after a major maintenance outage or a minor facility reconfiguration (one affecting a small number of subsystems). Pre-run facility startup activities would typically be performed prior to the start of a run period and would include a subset of the full ISTP activities referred to in Section 3.2.1.1.

#### <u>Requirement</u>

The system shall provide the capability to perform a controlled startup of the facility, and verify that the facility systems are functioning correctly.

#### 3.2.1.2.1 Coil Cool-down

#### **Background**

First plasma and initial field line mapping will be performed with the coils around room temperature to facilitate engineering shakedown and testing with portions of the cryostat removed. The coils will not be cooled to cryogenic temperatures prior to first plasma, but the systems required to support operation at cryogenic temperatures will be provided as part of the MIE Project. (In this context, cryogenic temperatures are around 77K (the saturation temperature of liquid nitrogen at 1 atmosphere).

Prior to experimental operations, the cryo-resistive coils must be cooled down from room temperature to a pre-pulse operating temperature of approximately 80K. The coils are located in a dry nitrogen environment that is provided by the cryostat, which surrounds the magnets. In order to gain access to the interior of cryostat, the coils must be warmed up from operating temperature to room temperature. The anticipated operational plans are expected to result in up to less than 150 cool-down and warm-up cycles between room temperature and operating temperature over the lifetime of the machine.

#### 3.2.1.2.1.1 Timeline for Coil Cool-down to Cryogenic Temperature

The cryo-resistive coils (TF, PF, modular, and external trim coils) shall be capable of being cooled down from room temperature (293K) to their operating temperature (80K) within 96 hours.

#### 3.2.1.2.1.2 Cool-down and Warm-up Cycles

The design of the cryo-resistive coils shall allow for at least 150 cool-down and warm-up cycles between room temperature and cryogenic temperature.

#### 3.2.1.2.1.3 Pre-Run Temperatures

The device and facility shall be designed to be capable of operating the coils at cryogenic temperature (80K).

The device and facility shall be designed to maintain the vacuum vessel and all in-vessel components at a minimum temperature of at least 20°C when the coils are at cryogenic temperature and the machine is not being pulsed.

## 3.2.1.2.2 Vacuum Requirements

#### 3.2.1.2.2.1 Base Pressure

The device shall be designed and facility shall be upgradeable to produce, through design and the use of baking and wall conditioning, high vacuum conditions with a global leak rate of less than or equal to  $2x10^{-5}$  torr-l/s at 293K and, when equipped with a torus pumping speed of 2,600 l/s, a base pressure of less than or equal to  $2x10^{-8}$  torr.

The base pressure shall be measured with a standard, magnetically shielded, nude ion gauge. The device shall accommodate additional nude ion gauges and at least one fast neutral pressure gauge as future upgrades. The partial pressure components of the base pressure shall be measured with a Residual Gas Analyzer (RGA) mounted at a location on one of the pump ducts near the turbo-molecular pumps.

# 3.2.1.2.2.2 Pumping Speed

The device shall be designed and the facility shall be upgradeable to accommodate the four PBX-M 1500 l/s turbomolecular pumps (or equivalent), configured to provide a total net pumping speed at the torus of at least 2600 l/s.

The device shall be equipped with two of the four PBX-M 1500 l/s turbomolecular pumps (or equivalent) , configured to provide a total net pumping speed at the torus of at least 1,300 l/s.

#### 3.2.1.2.3 Bakeout

#### **Background**

The temperature of the vacuum vessel shell will be capable of being elevated to a nominal bakeout temperature of 150°C by circulating high temperature gas in tubes attached to the vacuum vessel shell and ports. Initially, there will not be any limiters installed in the vacuum vessel for first plasma or field line mapping. However, later in the program, a carbon-based liner will be installed inside the vacuum vessel with a surface area that is a substantial part of the vacuum vessel surface area to absorb the high heat loads and to protect the vacuum vessel and internal components. The temperature of the carbon-based liner will be elevated to a nominal bakeout temperature of 350°C by circulating high temperature gas in tubes attached to the liner assembly. Components that will become hot during bakeout operations must be compatible with their elevated temperatures in terms of strength, compliance for expansion, and vacuum integrity.

#### 3.2.1.2.3.1 Vacuum Vessel Bakeout Temperatures

During bakeout, the temperature of the vacuum vessel shell and ports shall be maintained at 150°C +5/-25°C.

#### 3.2.1.2.3.2 Carbon-based Plasma Facing Components (PFCs) Bakeout Temperatures

During bakeout, the temperature of the carbon-based PFCs (to be installed as a future upgrade) shall be maintained at 350°C±25°C. (The 350°C bakeout capability is an upgrade.)

#### 3.2.1.2.3.3 Coil Temperatures During Bakeout

During bakeout, the temperature of the cryo-resistive coils shall be capable of being kept below 90 K and returned to their pre-pulse operating temperatures within the 24 hours following completion of bakeout.

#### 3.2.1.2.3.4 Bakeout Timelines

The vacuum vessel and all components internal to the vacuum vessel shall be capable of being raised to their bakeout temperatures within 36 hours and maintained at that temperature indefinitely.

Following bakeout, the vacuum vessel and all components internal to the vacuum vessel shall be capable of being returned to 40°C within 36 hours.

## 3.2.1.2.3.5 Glow Discharge Cleaning (GDC) During Bakeout

The facility shall provide (as a future upgrade) a glow discharge cleaning (GDC) capability during bakeout operations, meeting the requirements of Section 3.2.1.4.1, except with the vacuum vessel and all components internal to the vacuum vessel at their nominal bakeout temperature.

## 3.2.1.2.3.6 Bakeout Cycles

The device shall be designed for at least 100 bakeout cycles over the life of the machine.

#### 3.2.1.3 Pre-operational Initialization and Verification

#### **Background**

Pre-operational initialization and verification activities would generally cover those activities required prior to the start of an operating day following an overnight or weekend shutdown.

#### <u>Requirement</u>

The system shall meet the following requirements in order to make experimental systems ready for the start of operations, and verify that experimental systems are functioning correctly.

#### 3.2.1.3.1 Plasma Chamber Conditioning

#### 3.2.1.3.1.1 Boronization

The facility shall provide (as a future upgrade) the capability for boronization for all surfaces with line-of-sight to the plasma.

#### 3.2.1.3.1.2 Lithiumization

The facility shall provide (as a future upgrade) the ability to apply lithium coatings, either via Li pellets or spray, or other techniques.

#### 3.2.1.4 Pre-pulse Initialization and Verification

#### **Background**

Pre-pulse initialization and verification activities cover those activities required prior to the start of each pulse (plasma discharge).

#### <u>Requirement</u>

The system shall make experimental systems ready for the start of a pulse (plasma discharge) and verify that the experimental systems are functioning correctly prior to the initiation of a pulse.

#### 3.2.1.4.1 Glow Discharge Cleaning (GDC) Between Pulses

The facility shall provide (as a future upgrade) the capability to perform GDC between pulses with the vacuum vessel and all components internal to the vacuum vessel at their nominal pre-pulse operating temperatures.

The facility shall be capable of using any of the following gases for GDC: hydrogen, deuterium, helium, and other non-corrosive gases.

Shutters shall be provided to prevent coating of windows during GDC. Shields shall be provided to prevent coating and high-resistance short circuits across insulators. Provision shall be made to isolate the neutral beams during GDC.

#### 3.2.1.4.2 **Pre-Pulse Temperature**

Interior vacuum vessel surfaces and all in-vessel components except for the Plasma Facing Components shall return to a prescribed pre-pulse temperature in the range of 40°C.

Interior vacuum vessel surfaces and all in-vessel components except for the Plasma Facing Components shall, as a future upgrade, be maintained at a temperature of 40°C in the presence of a hot liner with a temperature of 250 C. This is to facilitate the use of a lithium liner as a possible future upgrade.

The Plasma Facing Components shall have a minimum pre-pulse operating temperature of 40°C.

The cryo-resistive coils shall return to a pre-pulse temperature of about 80K, so as to prevent overheating during operation.

#### **3.2.1.5** Experimental Operations

#### 3.2.1.5.1 Field Error Requirements

Field error correction coils shall be provided to compensate for fabrication errors.

The toroidal flux in island regions due to fabrication errors, magnetic materials, and eddy currents shall not exceed 10% of the total toroidal flux in the plasma (including compensation).

#### **3.2.1.5.2** Electrical (Eddy Current) Requirements

#### **Background**

There are three fundamental reasons for establishing electrical (eddy current) requirements: plasma control, plasma stabilization, and field errors. The plasma will be initiated inductively on closed magnetic surfaces. The PF coils will apply the inductive voltage for plasma initiation and current drive. The toroidal resistance of the surrounding structures must be sufficiently high in order for the voltage to penetrate to the plasma chamber. Limitations on time constants for poloidal currents in the surrounding structures are also required to allow the magnetic fields from the TF and modular coils to penetrate.

The second reason is related to stabilizing external kink modes. The presence of a close-fitting conducting shell can stabilize external kink modes. The longest time constant of close-fitting conducting shells (like the vacuum vessel) should be short enough to preclude kink mode stabilization.

The third reason is related to field errors and their effect on surface quality in the plasma. Eddy currents can give rise to field errors that in turn, can create unacceptably large islands or destroy the outer surfaces of the plasma.

#### **Requirements**

The time constant of the longest-lived eddy current eigenmode of the vacuum vessel and in-vessel structures must be less than 10 ms.

The stellarator core structure out to and including the cryostat (except the vacuum vessel and coils) shall include electrical breaks to avoid having a toroidally continuous current path.

The time constant of the longest-lived eddy current eigenmode in the electrically conducting structures outside the vacuum vessel and inside the cryostat (except coils) shall be less than 20 ms.

Eddy currents in conducting structures surrounding the plasma shall not give rise to unacceptable field errors, as defined in Section 3.2.1.5.1.

Stellarator symmetry shall be preserved in the design of the vacuum vessel, in-vessel structures, and electrically conducting structures outside the vacuum vessel in the stellarator core out to and including the cryostat.

The machine shall be positioned high enough above the ground plane such that eddy currents in the ground plane shall not give rise to unacceptable field errors, as defined in Section 3.2.1.5.1.

#### 3.2.1.5.3 Plasma Magnetic Field Requirements

#### 3.2.1.5.3.1 Coordinate System

Figure 3-2 illustrates the right-handed coordinate system used for the stellarator and test cell on NCSX. The Z-axis of the coordinate system is vertical. The major axis of the stellarator is coincident with the Z-axis. The following conventions are followed:

- A positive toroidal (plasma) current or a positive toroidal magnetic field point in the φ-direction (counterclockwise viewed from above).
- A positive vertical magnetic field points in the Z-direction (upward).
- A positive poloidal current (TF or modular coil current in the inner leg) flows in the Z-direction and provides a positive toroidal magnetic field.
- Positive radial magnetic fields and currents are in the R-direction, radially outward from the Z-axis, the major axis of the stellarator.

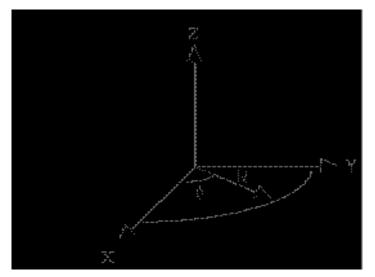


Figure 3-2 NCSX Coordinate System

# 3.2.1.5.3.2 Magnetic Field Polarity

The facility shall be configured for the standard magnetic field polarity to have its toroidal field in the negative direction.

The facility shall have the capability to be reconfigured to operate with the magnetic field polarity reversed from its standard direction.

#### 3.2.1.5.3.3 Reference Scenarios

#### **Background**

NCSX is designed to be a flexible, experimental test bed. To ensure adequate dynamic flexibility, a series of reference scenarios has been established. TF, PF, and modular coil systems and the vacuum vessel will be designed for a plasma with a nominal major radius of 1.4 m and capability to meet the requirements of all the reference scenarios. Electrical power systems shall be designed and initially configured to meet the requirements of the First Plasma and Field Line Mapping Scenarios and shall be capable of being upgraded to meet the requirements of all other reference scenarios.

The NCSX Project will document coil current center geometries, the first wall surface geometry, and coil current waveforms required for each reference scenario in technical data files.

#### **3.2.1.5.3.3.1** Reference Scenario Specifications

#### **Background**

This section provides the specifications for each of the reference scenarios, while the requirements themselves are provided in Section 3.2.1.5.3.3.2. Reference waveforms of engineering parameters such as coil currents, voltages, power dissipation, etc. are derived from the scenario specifications.

# 3.2.1.5.3.3.1.1 First Plasma Scenario

The First Plasma Scenario is characterized by:

- A magnetic field on axis (R=1.4m) of at least 0.5 T
- A plasma current of at least 25 kA

• At least 50% of the rotational transform provided by stellarator magnetic fields.

## 3.2.1.5.3.3.1.2 Field Line Mapping Scenario

The Field Line Mapping Scenario is characterized by:

- Ramping the coils to a magnetic field on axis (R=1.4m) of 0.1T. The vacuum iota shall be above 0.5 in the outer half of the plasma.
- Maintain a constant field on axis for 10 seconds.

#### 3.2.1.5.3.3.1.3 1.7T Ohmic Scenario

The 1.7T Ohmic Scenario is characterized by:

- Ramping the coils to their pre-initiation values at a magnetic field on axis (R=1.4m) of 1.7T. The vacuum iota shall be above 0.5 in the outer half of the plasma.
- Holding the coils at pre-initiation values for 100ms
- Inductively initiating the plasma and ramping the plasma current to its maximum value of 120kA at a rate of 3MA/s
- Maintaining the plasma current constant for 300ms

## 3.2.1.5.3.3.1.4 1.7T High Beta Scenario

The 1.7T High Beta Scenario is characterized by:

- Ramping the coils to their pre-initiation values at a magnetic field on axis (R=1.4m) of 1.7T. The vacuum iota shall be above 0.5 in the outer half of the plasma.
- Holding the coils at pre-initiation values for 100ms.
- Inductively initiating the plasma and ramping the plasma current to 120kA at a rate of 3MA/s.
- Heating the plasma to a beta greater than 4% while ramping the plasma current to 175 kA in 100ms.
- Maintaining the plasma current and beta constant for 200ms

#### 3.2.1.5.3.3.1.5 1.2T High Beta Long-Pulse Scenario

The 1.2T High Beta Long Pulse Scenario is characterized by:

- Ramping the coils to their pre-initiation values at a magnetic field on axis (R=1.4m) of 1.2T. The vacuum iota shall be above 0.5 in the outer half of the plasma.
- Holding the coils at pre-initiation values for 100ms
- Inductively initiating the plasma and ramping the plasma current to 85kA at a rate of 3MA/s.
- Heating the plasma to a beta greater than 4% while ramping the plasma current to 125 kA in 100ms.
- Maintaining the plasma current and beta constant for 1.5 sec

# 3.2.1.5.3.3.1.6 2T High Beta Scenario

The 2T High Beta Scenario is characterized by:

- Ramping the coils to their pre-initiation values at a magnetic field on axis (R=1.4m) of 2T
- Holding the coils at pre-initiation values for 50ms
- Inductively initiating the plasma and ramping the plasma current to 134kA at a rate of 3MA/s

• Heating the plasma to a beta greater than 4% while ramping the plasma current to 200 kA in 100ms

# 3.2.1.5.3.3.1.7 320 kA Ohmic Scenario

The 320 kA Ohmic Scenario is characterized by:

- Ramping the coils to their pre-initiation values at a magnetic field on axis (R=1.4m) of 1.7T
- Holding the coils at pre-initiation values for 100ms
- Inductively initiating the plasma and ramping the plasma current to its maximum value of 320kA at a rate of 3MA/s
- Maintaining the plasma current constant for 300ms

## 3.2.1.5.3.3.2 Reference Scenario Requirements

TF, PF, and modular coil systems and the vacuum vessel will be designed to meet the requirements of all the reference scenarios.

Electrical power and cryogenic systems shall be designed and initially configured to meet the requirements of the First Plasma and Field Line Mapping Scenarios and shall be capable of being upgraded to meet the requirements of all other reference scenarios.

## 3.2.1.5.3.4 Flexibility Requirements

## **Background**

NCSX is designed to be a flexible, experimental test bed. To ensure that changes in equilibria can be accommodated, several dimensions have been identified over which changes in equilibria must be accommodated.

Flexibility requirements have been established for a toroidal magnetic field of 1.7T. Greater flexibility exists at lower field levels.

The NCSX Project will provide coil currents in technical data files required for each equilibrium at the extremes in flexibility space.

#### 3.2.1.5.3.4.1 Quasi-axisymmetry Flexibility

The coils shall be designed and the power systems shall be upgradeable to vary quasi-symmetry by varying the effective ripple from the reference value to 10 times the reference value.

# 3.2.1.5.3.4.2 External Iota Flexibility

The coils shall be designed and the power systems shall be upgradeable to vary the rotational transform from -0.2 to +0.2 (**TBR**), relative to the reference profile, while holding the global shear ( $\iota(a)$ - $\iota(0)$ ~0.2), plasma current (175kA), and toroidal magnetic field (1.7T at R=1.4m) constant.

#### 3.2.1.5.3.4.3 Shear Flexibility

The coils shall be designed and the power systems shall be upgradeable to vary the shear by varying the global shear (equal to  $\iota(a)$ - $\iota(0)$ ) by -0.2 to +0.2 (**TBR**), relative to the reference value, while holding the central iota (0.4), plasma current (175kA), toroidal magnetic field (1.7T at R=1.4m) constant

#### 3.2.1.5.3.4.4 Beta Limit Flexibility

The coils shall be designed and the power systems shall be upgradeable to be capable of reducing the kink stability beta limit to 1% from its reference value of  $\sim 4\%$ .

#### 3.2.1.5.3.4.5 Radial and Vertical Position Flexibility

The coils shall be designed and the power systems shall be upgradeable to be capable of varying the radial position of the magnetic axis by  $\pm 16$  cm relative to the nominal position, and the vertical position by  $\pm 2$  cm relative to the midplane. **(TBR)** 

(Note that this applies only to the coils and power supplies and does not imply any requirement on the Plasma Facing Components.)

#### 3.2.1.5.3.5 Equilibrium Control

Feedback equilibrium control systems for radial and vertical plasma position control shall be provided (as a future upgrade).

#### 3.2.1.5.3.6 Breakdown Loop Voltage

The coils and power supplies shall be designed to be capable of producing a loop voltage of 3 V for plasma breakdown under dirty plasma conditions.

The power supplies shall be upgradeable to be capable of producing a loop voltage of 5 V.

#### 3.2.1.5.3.7 Power Supply Ripple

The power systems shall be designed with low enough voltage and current ripple so as not to interfere with magnetic diagnostic measurements or plasma equilibrium control.

#### 3.2.1.5.3.8 Coil Current Measurements

Coil currents shall be continuously measured during a pulse with an accuracy of 0.1% of the peak power supply current.

#### 3.2.1.5.4 Power Handling

#### **Background**

PFCs serve the following functions: a) Provide for limiter operation, b) Provide for divertor operation including power handling, neutral recycling, and density control, and c) protect the vacuum vessel and in-vessel components from particle and radiation heat loads from the plasma (including energetic ions) and from the shinethrough of neutral beams through the plasma.

Initially, the device will not be configured with any PFCs. Upgrades to the PFC system will be incrementally made in response to experimental program needs to provide all of the functions above.

#### 3.2.1.5.4.1 PFC Configuration

Coverage. The capability to expand the coverage by the PFCs (as a future upgrade) to 100% shall be provided.

<u>Materials.</u> Future upgrades for a carbon fiber composite (CFC), lithium, tungsten, or molybdenum liner shall be accommodated. Materials used inside the vacuum vessel shall, unless otherwise authorized by the project, be compatible with lithium, in order to facilitate the use of a lithium liner as a possible future upgrade. The vacuum vessel and support system must be capable of supporting the weight of all in-vessel components, including upgrades, and maintain their alignment (including tungsten and molybdenum liner upgrades).

<u>Poloidal limiters</u>. The capability to accommodate an array of graphite or CFC poloidal limiters (as a future upgrade) shall be provided on the v=0.5 cross section.

Divertor capability. The capability to accommodate a divertor (as a future upgrade) shall be provided.

<u>Divertor pumping</u>. The capability to configure the divertor (as a future upgrade) with a slot, permitting neutral particles passage into a plenum that is actively pumped (with a cryopump or titanium getter pump), shall be provided.

<u>Electrical biasing</u>. The capability to electrically bias regions of the plasma boundary up to 1000 V relative to each other and the vacuum vessel (as a future upgrade) shall be provided.

<u>Armor</u>. The capability to add armor to protect the vacuum vessel, port extensions, and in-vessel components from neutral beam shinethrough and from fast ions lost from the plasma (as future upgrades) shall be provided.

#### 3.2.1.5.4.2 Maximum Plasma Heating Power

The capability to accommodate (as a future upgrade) heat loads associated with up to 12MW of plasma heating power for 1.2s (including 6MW of neutral beam injection) shall be provided.

#### 3.2.1.5.4.3 Maximum Component Surface Temperature

The maximum surface temperature for carbon-based PFCs shall not exceed 1200°C.

#### 3.2.1.5.5 Disruption Handling

The facility shall be designed to withstand electromagnetic forces due to major disruptions characterized by instantaneous disappearance of the plasma at with a maximum plasma current of 320 kA.

Note: Instantaneous decay is assumed for simplicity and is conservative for EM load calculations. Induced voltage effects due to disruptions are ignored because of the relatively low plasma current and continuous vacuum vessel in NCSX.

#### 3.2.1.5.6 Plasma Heating

#### 3.2.1.5.6.1 Neutral Beam Heating

#### 3.2.1.5.6.1.1 Initial Neutral Beam Heating Complement

One beamline previously used on the PBX-M project will be installed as part of the NCSX Fabrication Project to provide 1.5 MW of neutral beam heating power with a minimum of 0.3 s of pulse length. The beam will be configured in the co-direction (the nominal direction of the plasma current) The tangency radius shall be inside the magnetic axis for the nominal 1.7T high beta equilibrium and located such that the beam does not intercept the inboard first wall.

#### **3.2.1.5.6.1.2** Ultimate Neutral Beam Heating Complement

The facility shall be designed to accommodate future neutral beam heating upgrades up to 6 MW of power and up to 1.2 s of pulse length using the four (4) beamlines previously used on PBX-M in two possible configurations: a) 2 co- and 2 counter-directed beamlines and b) 3 co- and 1 counter-directed beamlines.

#### **3.2.1.5.6.2** Ion Cyclotron Heating (ICH)

The facility shall be designed to accommodate 6 MW of ICH (as a future upgrade) with a pulse length of 1.2s and frequency of 20-30 MHz.

The facility shall be designed to accommodate three sets of launchers on the inboard side, one at each of the three v=0.5 cross-sections.

#### **3.2.1.5.6.3** Electron Cyclotron Heating (ECH)

The facility shall be designed to accommodate 3 MW of ECH (as a future upgrade) with a pulse length of 1.2s and frequency of 70-140 GHz.

# 3.2.1.5.7 Plasma Fueling

## 3.2.1.5.7.1 Fuel Species

The facility shall be designed to be fueled with hydrogen (H), deuterium (D), helium (He), or other non-corrosive gases.

#### 3.2.1.5.7.2 Gas Injection

The device and facility shall have a programmable gas injection system capable of injecting any one or a combination of the fuel species specified in Section 3.2.1.5.7.1.

The system shall provide one injector per period (total of 3), each with a maximum flow rate of at least 50 torr-l/sec.

The system shall have the capability to accommodate as future upgrades:

- Up to four injectors per period (inboard, outboard, and top and bottom divertors).
- One outboard and one inboard supersonic injector per period.
- One inboard injector per period for either gas or pellets.
- Feedback on real-time density measurement.

#### 3.2.1.5.7.3 Pellet Injection

The facility shall incorporate guide tubes to accommodate pellet launch from the inboard (high-field) side of the plasma.

The device and facility shall be designed to accommodate (as a future upgrade) a single pellet injector capable of repetitively injecting H or D pellets.

#### 3.2.1.5.8 Plasma Diagnostics

#### 3.2.1.5.8.1 General Diagnostics Requirements

Diagnostic measurements of the plasma parameters that are: a) critical to the research goals of NCSX and b) necessary for plasma control and operational purposes shall be provided.

#### 3.2.1.5.8.2 Diagnostics Implementation

All magnetic trapped sensors (e.g., those located between the coils and vacuum vessel or co-wound with the coil), magnetic diagnostics signal processing electronics needed to measure plasma current, a fast visible camera, and field mapping apparatus (e-beam, fluorescent probe, camera) shall be provided.

The facility shall be designed to accommodate the diagnostics identified in Table 3-2 as future upgrades.

# Table 3-2 Diagnostic Requirements

	research topic	essential new measurements	new diagnostics
1. lı	nitial Operation		
	initiate plasma: exercise coil set	plasma current	plasma current Rogowskis
	lp >25 kA	conductivity	flux loops
	checkout vacuum diagnostics	plasma position	saddle loops
	checkout magnetic diagnostics	plasma stored energy	B-dot probes
	initial wall conditioning		diamagnetic loop
	~	plasma/wall imaging	fast visible cameras
		line integrated density	1 mm interferometer
2. F	ield Line Mapping		
	map flux surfaces	vacuum flux surfaces	e-beam probe
	verify iota and QA	variable energy trace particles	fluorescent rod probe
			high dynamic range CCD
3. lı	nitial Ohmic		l I
	initial plasma control, plasma evolution control	electron density profiles	multichord FIR interf./ polarim.
	global confinement & scaling, effect of 3D shaping	electron temperature profiles	Thomson scattering
	density limit & mechanisms	radiated power profiles	core foil bolometer array
	study of Te and ne profiles.	magetic axis position	compact SXR arrays
	vertical stability	low (m,n) MHD (<100kHz)	
	current-driven kink stability	flux surface topology	
	effect of low-order rat. surf. on flux-surface topology	impurity species	visible spectrometer
	initial study of effect of trim coils, both signs	impurity concentration	abs. UV spectroscopy
	effect of contact location on plasma edge & recycling	Zeff	filtered 1D CCD camera
	initial attempts to control plasma contact location	hydrogen recycling	visible filterscopes
	nitial Aux. Heating	,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,	1
	plasma control with NB heating and CD		diagnostic neutral beam
	test of kink & ballooning stability at moderate beta	ion temperature profile	toroidal CHERS
	effect of shaping on MHD stability	toroidal rotation profile	
	initial study of Alfvenic modes w/ NB ions	poloidal rotation profile	poloidal CHERS
	confinement scaling w/ iota, B,	radial electric field	MSE polarimeter
	local transport measurements, perturb. meas.	iota profile	
	test of quasi-symmetry on confinement and transport	fast ion loss	fast ion loss probe
	density limits and control with heating	ion energy distribution	neutral particle analyser
	use of trim coils to minimize rotation damping	neutron flux	epithermal neutron detector
	blip measurements of fast ion conf. and slowing down	first wall surface temperature	compact IR cameras
	initial attempts to obtain enhance confinement regimes	high frequency MHD(<5Mhz)	high frequency Mirnov coils
	pressure effects on surface quality		fast tang. x-ray pinhole camera
	controlled study of neoclassical tearing using trim coils		enhanced x-ray tomography
	wall coatings with aux. heating	SOL tmperature and density	moveable Langmuir probe
	edge and exhaust charact. with aux. heating	neutral pressure	fast neutral pressure gauges
	attempts to control wall neutral influx	target Te, ne	plate mounted Langmuir probes
	wall biasing effects on confinement		
5. C	onfinement & beta push		
	stability tests at beta >~ 4%	edge/div. radiated power profile	divertor foil bolometer arrays
	detailed study of beta limit scaling	divertor recycling	divertor filtered CCD cameras
	detailed studies of beta limiting mechanisms	edge temp. and dens. prof.	fast scanning edge probe
	disruption-free operating region at high beta	divertor target surface temp.	fast IR camera
	active mapping of Alfvenic mode stability (with antenna)		divertor thermocouples
	enh. conf.: H-mode, hot ion modes, RI mode, pellets	core helium density	He CHERS system (with DNB)
	enhanced confinement, rotation effects		
	scaling of local transport and confinement	divertor impurity concentration	divertor UV spectroscopy
	turbulence studies	core density fluct. amp. & spec	fluctuation diagnostics TBD
	scaling of power or other thresholds for enh. conf.		
	ICRF wave propagation and damping (possible)		
	perturbative RF measurements of transport (possible)		
	divertor operation optimized for power handling		
	trace helium exhaust and confinement		
	scaling of power to divertor		
	control of high beta plasmas and their evolution		
6. L	ong Pulse		
	long pulse plasma evolution control	more detailed divertor profiles	divertor Thomson scattering
	equilibration of current profile		divertor diagnostics (TBD)

#### 3.2.1.5.9 Instrumentation, Control, and Data Acquisition

The NCSX facility shall have a flexible instrumentation, control, and data acquisition (central I&C) system that allows for coordination of operations and the acquisition, archiving, and display of all pertinent information.

Archiving of data shall be done in a way that enables the data be retrieved with widely available cross-platform software.

Archived data shall be protected from loss or destruction by maintaining multiple copies, including off-site storage.

#### 3.2.1.5.10 Pulse Repetition Rate

The facility shall be designed for pulses to be initiated at intervals not exceeding 15 minutes when constrained by coil cool-down, Plasma Facing Component cool-down, or glow discharge cleaning (GDC) and 5 minutes otherwise.

#### 3.2.1.5.11 Discharge Termination

#### 3.2.1.5.11.1 Normal Termination

#### **Background**

Normal termination includes all system actions necessary to shutdown the plasma and associated subsystems at the conclusion of a pulse in preparation for the next pulse.

#### <u>Requirement</u>

The NCSX system shall provide the capability to perform a controlled shutdown of the plasma and associated subsystems at the conclusion of a pulse.

#### 3.2.1.5.11.2 Abnormal Termination

#### **Background**

Abnormal termination consists of all system responses necessary to remove conditions that occur during experimental operations that could cause significant damage to the NCSX system or cause injury to personnel.

#### **Requirement**

The NCSX system shall provide the capability to shut down the plasma and associated subsystems if a condition occurs during experimental operation that could cause significant equipment damage or cause injury to personnel.

#### 3.2.1.6 Facility Shutdown

#### **Background**

Facility shutdown involves the shutdown of NCSX equipment following the termination of a discharge (per Section 3.2.1.5.11) in preparation for a brief (overnight or weekend) or extended (between run periods) shutdown.

#### **Requirement**

The NCSX system shall provide the capability to perform a controlled shutdown of the facility.

#### 3.2.1.6.1 Coil Warm-up Timeline

The cryo-resistive coils (TF, PF, and modular coils) shall be capable of being warmed up from operating temperature (80K) to room temperature (293K) within 96 hours.

#### 3.2.1.6.2 Vacuum Vessel Venting

Provisions shall be made to vent the vacuum vessel in preparation for a vacuum opening.

## 3.2.2 External Interface Requirements

#### 3.2.2.1 Shelter

NCSX will be sited at C-site at PPPL. The NCSX Test Cell will be the same test cell first used for the C-Stellarator and subsequently used for the PLT and PBX-M tokamaks. It is assumed that the NCSX Test Cell, basement, and adjoining rooms utilized by the NCSX Project will be received equipped with proper:

- Shelter from the environment (roofing and walls)
- Lighting
- Environmental (temperature, humidity, and air exchange) control
- Fire suppression

#### 3.2.2.2 Water Systems

It is assumed that the facility water systems to be used by NCSX will be received in a fully operational condition. The NCSX Project will be responsible for adding cooling loops as required for NCSX subsystems.

## 3.2.2.3 Electrical Power

Electrical power for the TF, PF, and modular coils will be provided through the D-site experimental power systems. All other electrical power for NCSX will be provided through the C-site experimental power systems.

## 3.2.2.4 Utility Gas Systems

The facility shall provide gaseous nitrogen and compressed air as utility services to the core machine and diagnostics for general use such as venting the vessel to atmospheric pressure and actuating valves and shutters.

# **3.2.3** Physical Characteristics

#### 3.2.3.1 Test Cell Compatibility

#### **Background**

NCSX will be sited in an existing test cell. NCSX equipment shall be designed to be within the lift capacity of the existing overhead crane, fit through the existing door, and be within existing floor loading limitations.

#### 3.2.3.1.1 Maximum Lift

The maximum lift required to assemble, maintain, and disassemble NCSX shall not require an overhead crane capacity exceeding 30 tons.

#### 3.2.3.1.2 Maximum Dimensions

Each assembly entering and leaving the test cell must be able to fit through a rectangular door that is 17'6" feet wide and 16 feet high.

# 3.2.3.1.3 Maximum Floor Loading

#### 3.2.3.1.3.1 Test Cell Floor Loading

The maximum floor loading in the Test Cell shall not exceed 4,500 pounds per square foot.

#### 3.2.3.1.3.2 Platform Floor Loading

The maximum floor loading on the platform surrounding the machine is 250 pounds per square foot.

#### 3.2.4 System Quality Factors

#### 3.2.4.1 Reliability, Availability, and Maintainability

#### **Background**

The overall objective is to provide a device with high operational availability, meaning that the number of plasma discharges achieved in a run period is a large percentage (greater than 75%) of the number planned after the initial shakedown and commissioning phases of the facility. Bottoms-up reliability predictions are difficult to perform and have large uncertainties for first-of-a-kind experimental devices such as NCSX. Therefore, quantitative RAM requirements on NCSX will be few. Rather, NCSX will rather rely on sound engineering practice to assure high availability in NCSX, which has been the tried-and-true approach on similar scale fusion devices. Sound engineering practices include:

- Applying design principles that promote reliability (e.g., employing an adequate factor of safety on mechanical and electrical stresses, avoiding unnecessary complexity, using proven design approaches and well characterized materials, etc.)
- Optimizing designs for reliability and maintainability through systematic evaluation of design options,
- Performing failure modes, effects and criticality analysis (FMECAs) for RAM design improvement and verification, and
- Employing peer reviews as a mechanism to enhance the design process.

The NCSX RAM Plan defines the processes that will be used by the Project to achieve a device with high availability.

#### **Requirements**

NCSX shall incorporate reliability and maintainability features in the design that are consistent with achieving a high (greater than 75%) operational availability after the initial shakedown and commissioning phases of the facility.

The device and components internal to the vacuum vessel shall be designed for installation and maintenance by personnel entering and working inside the vacuum vessel.

The facility shall include a work platform surrounding the device to provide access to the device and diagnostic equipment.

Provisions for recovery shall be made for every credible failure mode.

The stellarator core shall be capable of being disassembled and reassembled within one year to permit replacement of any part or machine reconfiguration that would require disassembly.

Assemblies that exceed two man manual lift limits shall include provisions for lifting eyes or other sling attach provisions.

#### 3.2.4.2 Design Life

The facility shall have a design life of >10 years when operated per the reference scenarios defined in Section 3.2.1.5.3.3.1.

The facility shall be designed for the following maximum number of pulses when operated per the reference scenarios defined in Section 3.2.1.5.3.3.1 and based on the factors for fatigue life specified in the NCSX Structural and Cryogenic Design Criteria Document:

• 100 per day;

- 13,000 per year; and
- 130,000 lifetime.

#### 3.2.5 Transportability

All assemblies and components shall be transportable by commercial carrier via highway, air, sea, or railway. All system elements that are unsuitable, due to operational or functional characteristics, for normal transportation methods by highway, air, or railway shall be identified.

#### **3.3** Design and Construction

## 3.3.1 Materials, Processes, and Parts

## 3.3.1.1 Magnetic Permeability

All materials to be used in the stellarator and peripheral equipment inside the cryostat must have a relative magnetic permeability less than 1.02 unless otherwise authorized by the Project.

## 3.3.1.2 Vacuum Compatibility

The vacuum vessel interior and all in-vessel metallic components shall be electropolished prior to installation, except when authorized by the project.

The vacuum vessel interior shall be degreased and cleaned prior to installation. All in-vessel components shall be made of vacuum compatible materials and degreased and cleaned. They shall be vacuum baked prior to installation, except when authorized by the project.

All in-vessel materials shall be approved by the Project for vacuum compatibility. Pre-approved materials are catalogued in the NCSX Vacuum Materials List.

The system shall be designed for high vacuum compatibility: All appendages, ports and diagnostics that are not to be left open permanently to the vacuum vessel shall have their own pumping system and conditioning capabilities to maintain required conditions when opened to the vacuum vessel. All systems and components either in vacuum or with a vacuum interface should be designed to preclude trapped volumes and virtual leaks. The system shall be designed to allow for leak checking and repair of leaks on the vacuum vessel.

#### 3.3.1.3 Structural and Cryogenic Criteria

NCSX stellarator systems shall be designed in accordance with the NCSX Structural and Cryogenic Design Criteria.

#### 3.3.1.4 Corrosion Prevention and Control

Materials, processes, and protective surface treatments or finishes shall be provided to ensure that equipment capability during its service life is not degraded due to corrosion. Where possible, contact between dissimilar metals shall be avoided.

#### 3.3.1.5 Seismic Criteria

NCSX systems shall be designed in accordance with seismic design and evaluation criteria for Performance Category 1 (PC1) facilities, per DOE-STD-1020-2002, "Natural Phenomena Hazards Design and Evaluation Criteria for Department of Energy Facilities."

#### 3.3.1.6 Metrology

The NCSX device shall provide features (e.g., fiducial markers on the coils and vacuum vessel) to facilitate accurately measuring and locating components relative to the magnetic field for the life of the machine.

## 3.3.2 Electrical Grounding

A single-point electrical grounding system shall be provided in accordance with the NCSX Grounding Specification for Personnel and Equipment Safety.

A ground-loop detection system shall be provided to facilitate maintaining the integrity of the grounding system.

Voltage isolation shall be provided between the VV and systems attached to the vacuum vessel, in accordance with the NCSX Grounding Specification for Personnel and Equipment Safety.

RF Shielding shall be provided in accordance with the NCSX Grounding Specification for Personnel and Equipment Safety.

#### 3.3.3 Nameplates and Product Marking

#### 3.3.3.1 Labels

Equipment and any parts of that equipment to be used by personnel shall be identified with appropriate labels. Labels shall indicate clearly and concisely the function and purpose of the item being labeled. Hierarchical labeling shall be used to facilitate component location on control panels. The terminology used for equipment, procedures, and training materials shall be the same for each case. Label design shall be consistent to promote simplicity and avoid clutter. The use of abbreviations and acronyms shall be minimized. Permanent labels shall be attached to the specific component or equipment in such a manner that environmental conditions or usage by personnel will not remove or destroy the label. Temporary labels shall be used only when necessary and shall not obscure other information or equipment. If a temporary label is to designate a device that is out of service, the label shall be applied so that it prevents the use of that device. Labeling shall be legible and conform to human visual capabilities and limitations in regard to physical characteristics.

## 3.3.4 Workmanship

During NCSX fabrication and finishing, particular attention shall be given to freedom from blemishes, defects, burrs, and sharp edges; accuracy of dimensioning radii of weld fillets; making of parts; thoroughness of cleaning; quality of brazing, welding, riveting, painting, and wiring; alignment of parts; and tightness and torquing of fasteners.

#### 3.3.5 Interchangeability

Design tolerances shall permit parts and assemblies of the same part number to be used as replacement parts without degrading the specified performance of the parent item.

#### 3.3.6 Environmental, Safety, and Health (ES&H) Requirements

#### 3.3.6.1 General Safety

When utilized within its intended use and within specified environments, the safe operation, test, handling, maintenance and storage of the system hardware and software shall be provided.

The system shall not present any uncontrolled safety or health hazard to user personnel.

The system shall detect abnormal operating conditions and safeguard the NCSX system and personnel.

#### 3.3.6.2 Safety Hazards

#### 3.3.6.2.1 Radiation Monitoring

For plasma operations (and depending on experimental plans and operational experience), fixed and/or portable gamma and neutron radiation monitors may be set up at various locations inside and outside the NCSX Test Cell.

Locations for these monitors will be determined by the PPPL Health Physics organization, in conjunction with the NCSX organization.

# 3.3.6.2.2 Controlled Access System

A controlled access system (CAS) shall protect against inadvertent entry into the NCSX Test Cell when electrical, magnetic, mechanical, toxic, or radiation hazards exceed allowable limits.

The CAS shall be upgradeable to allow controlled access periods of at least five (5) minutes in the NCSX Test Cell between shots without impacting a 15-minute pulse repetition rate.

#### **3.3.6.2.3** Toxic Gases

## **Background**

Toxic gases such as tri-methyl boron (TMB) are sometimes used to perform GDC. Potential hazards can be controlled by selecting GDC gases with reduced toxicity, minimizing the gas inventory (through the use of small storage containers and compact distribution systems), implementing controls to shut down the flow of such gases in the event that the glow discharge is extinguished, and venting the effluent from the plasma chamber in a manner that there is no risk to personnel safety.

#### <u>Requirement</u>

Safeguards shall be implemented regarding the use of toxic gases for GDC to mitigate potential safety hazards.

## 3.3.6.2.4 Oxygen Depletion

#### **Background**

The cryostat is filled with cold (80K), dry nitrogen gas and maintained at a pressure slightly above atmospheric to prevent moisture from leaking into the cryostat. Excessive leakage of nitrogen gas represents a possible mechanism for oxygen depletion in the vicinity of the cryostat. The air in the test cell should be constantly exchanged and oxygen levels monitored to ensure personnel safety.

#### <u>Requirement</u>

The air in the NCSX Test Cell shall be exchanged once per **TBD** hours when the cryostat is pressurized with dry nitrogen.

Oxygen levels in the vicinity of the cryostat shall be monitored and alarmed to detect excessive leakage of nitrogen from the cryostat.

The cryostat shall be carefully air purged, monitored, and certified safe before cryostat panels are removed and personnel are allowed to enter.

#### 3.3.6.2.5 Vacuum Implosion

Vacuum windows of 4 inches diameter or greater shall incorporate protection from accidental vacuum implosion.

#### 3.3.6.3 Personnel Safety

The system shall meet all applicable OSHA requirements in accordance with 29CFR1910. The system shall limit personnel exposure to hazardous materials to below their OSHA permissible exposure limit (PEL).

#### 3.3.6.4 Flammability

The use of flammable materials shall be minimized.

Components containing flammable materials, fluids or gases shall be designed to minimize the possibility of leaks and spills.

#### 3.3.6.5 Fire Suppression

A fire suppression system shall be provided for the NCSX system, which meets the requirements of DOE O 420.1 and PPPL ESHD-5008.

## 3.3.6.6 Hazardous Materials

Radioactive and hazardous waste shall be handled in accordance with federal, state, and local standards.

#### 3.3.6.7 Electrical Safety

Electrical apparatus and systems shall be designed so that two simultaneous failures of high voltage (>600 V) barriers or a single failure of a low voltage barrier would have to occur to endanger workers performing work processes.

Designs shall comply with the requirements of PPPL-ES&HD-5008, Section 2.

## 3.3.6.8 Radiological Design Objectives

## **Background**

NCSX is being situated in the test cell previously used for the PBX-M experiment. It is expected that NCSX will produce fewer neutrons than PBX-M produced in its peak years. The plan is to reconfigure the shield walls to provide about the same level of shielding that was provided for PBX-M and to administratively limit deuterium (D) operation to keep personnel exposure within radiological limits. It is anticipated that annual DD neutron yields would be limited to approximately  $2.3 \times 10^{16}$  per year in order to limit the neutron dose-equivalent in the control room to 500 mrem per year.

#### <u>Requirement</u>

Deuterium (D) operation shall be administratively limited to keep personnel exposure within the radiological limits and design objectives of Table 3-3.

			Public Exposure <sup>1</sup>		Occupational	Exposure
Condition		P, Probability Of Occurrence In A Year	Regulatory Limit (rem per yr)	Design Objective (rem per yr)	Regulatory Limit (rem per yr)	Design Objective (rem per yr)
Routine Operation <sup>2</sup>	Normal Operations	P~1	0.1 total 0.01 airborne <sup>3</sup> 0.004 drinking water	0.01 total	5	1
	Anticipated Events	1>P≥10-2	0.5 total (including normal operation)	0.05 per event		
Accidents <sup>4</sup>	Unlikely Events	10 <sup>-2</sup> >P≥10 <sup>-4</sup>	2.5	0.5	ref <sup>5</sup>	ref <sup>5</sup>
	Extremely Unlikely	10-4>P≥10-6	25	5 <sup>6</sup>	ref <sup>5</sup>	ref <sup>5</sup>
	Events Incredible Events	P<10-6	NA	NA	NA	NA

# Table 3-3 Radiological Limits and Design Objectives

## 3.3.7 Human Engineering

Human factors technology shall be considered in the design, operation, and maintenance of the NCSX system. The criteria and requirements provided in this section are applicable to the design of the work environment and humanmachine systems at NCSX facilities. These criteria shall apply to new construction and to retrofitting of existing facilities. These criteria shall be considered for upgrading existing facilities where cost-benefit or risk-tradeoff analyses indicate justification for such expenditures.

#### 3.3.7.1 Anthropometry

Equipment that is to be used by personnel shall be designed or selected to accommodate the fifth to ninety-fifth percentile of the user population for stand-up and sit-down consoles and other work stations, for accessibility of equipment and instrumentation, for furniture and equipment layout, and for traffic flow.

# **3.3.7.2** Human Environments

# 3.3.7.2.1 Temperature and Humidity

Temperature and humidity for human environments shall be maintained within TBD limits.

<sup>&</sup>lt;sup>1</sup> Evaluated at the PPPL site boundary.

<sup>&</sup>lt;sup>2</sup> Dose equivalent to an individual from routine operations (rem per year unless otherwise indicated)

<sup>&</sup>lt;sup>3</sup> Compliance with this limit is to be determined by calculating the highest effective dose equivalent to any member of the public at any off site point where there is a residence, school, business, or office.

<sup>&</sup>lt;sup>4</sup> Dose equivalent to an individual from an accidental release (rem per event)

<sup>&</sup>lt;sup>5</sup> See Reference 4, Section 10, Item 10.1302 for exposure limits for emergency situations.

<sup>&</sup>lt;sup>6</sup> For design basis accidents (DBAs), i.e., postulated accidents or natural forces and resulting conditions for which the confinement structure, systems, components, and equipment must meet their functional goals, the design objective is 0.5 rem.

# 3.3.7.2.2 Ventilation

#### TBD

# 3.3.7.2.3 Lighting

Adequate light levels shall be provided.

## 3.3.7.2.4 Emergency Lighting

Emergency lighting systems shall be provided as required by NFPA 101.

#### **3.3.7.3 Protective Equipment**

The facility shall be designed to ensure worker access to appropriate protective equipment as prescribed in ESHD 5008, "PPPL Environment, Safety, and Health Directives."

#### 3.3.8 System Security

The system shall provide security features with the capability to protect against unauthorized access and use of the NCSX system.

#### 3.3.9 Government Furnished Property Usage

TBD

#### 3.4 Documentation

N/A

#### 3.5 Logistics

#### 3.5.1 Maintenance

The system shall be maintained using, to the extent possible, standard/common tools and existing multi-purpose test equipment. Use of new/special tools and the number of standard/common tools shall be minimized through maximum commonality of fasteners, clamps, adapters, and connectors.

#### 3.5.2 Supply

The NCSX system shall use the existing PPPL material system.

#### 3.5.3 Facilities

Maximum use shall be made of the existing facilities and equipment at PPPL. Modifications and new facilities shall be constructed only where existing facilities are not adequate to house, store, maintain, operate, or test NCSX equipment.

#### 3.6 Personnel and Training

TBD

# 3.7 Characteristics of Subordinate Elements

#### **Background**

In this section, the performance characteristics defined in Section 3.2.1 are allocated to the subsystem level. These allocated characteristics provide the basis for defining performance characteristics in subsystem specifications.

# **Requirements**

Allocated subsystem performance characteristics are defined in the Characteristics Allocation Matrix in Appendix B.

# **4 VERIFICATION OF REQUIREMENTS**

#### 4.1 General

This section identifies the methods to be used for verification of requirements in Section 3 of this specification. General definitions of basic verification methods are outlined in Section 4.2. System requirements will be allocated in part or total to lower-level NCSX element specifications as outlined in Section 4.3. Verification and qualification of individual components will be conducted in accordance with individual specifications. Verification of system requirements will require additional testing in operational or near-operational environments. Detailed planning for verification of all system requirements will be documented in the NCSX Test & Evaluation Plan.

## 4.2 Inspection Verification Methods

Verification of qualification shall be by examination, demonstration, test or analysis. Definition of examination, demonstration, test and analysis is as follows:

<u>Examination</u>: Examination is an element of inspection consisting of investigation, without the use of special laboratory appliances, procedures or supplies and services to determine conformance to those specified requirements which can be determined by such investigations. Examination is generally non-destructive and includes but is not limited to, simple physical manipulation, gauging and measurement, visual, auditory, olfactory, tactile, gustatory and other investigations.

<u>Test</u>: Test is an element of inspection denoting the determination of the properties or elements of supplies or components thereof by technical means, including functional operation and the application of established principles and procedures. The analysis of data derived from test is an integral part of the inspection element and shall not be confused with "Analysis" below.

<u>Demonstration</u>: Demonstration is an element of inspection that, although technically a variation of test, differs from "Test" above, by directness of approach in the verification of a requirement and is accomplished without the use of elaborate instrumentation or special equipment. Thus, operation of a representative configuration item (CI) in or near its use environment would be defined as a demonstration rather than a test.

<u>Analysis</u>: Analysis is an element of inspection in the form of a study resulting in data that is intended to verify a requirement when an examination, test, or demonstration cannot feasibly be employed to verify the requirement. Such data may be a compilation or interpretation of existing data, analysis, design solutions, and lower-level inspection results.

#### 4.3 Quality Conformance

#### **Background**

This section establishes the specific evaluation criteria for verification of the system requirements in Section 3. Each of the performance characteristics in Section 3.2.1 is associated with a verification method in the Quality Conformance Matrix in Appendix C. All other requirements in Section 3 flow down to individual subsystems and will be verified at a level below the system level. In general, all requirements shall be verified under operational or near-operational conditions as possible given test constraints.

#### **Requirements**

Test methods for each of the performance characteristics in Section 3.2.1 are identified in the Quality Conformance Matrix in Appendix C.

- 5 NOTES
- 5.1 Definitions

TBD

5.2 Acronyms

TBD

# Appendix A – Technical Data Sheet

## A.1 Coil Set Definition

Coil centroids are defined by the c08r00 coil set.

# A.2 Coil Inductance Matrix (Henries)

	M1	M2	M3	PF1	PF2	PF3	PF4	PF5	PF6	TF	Plasma
M1	1.24E-02	2.83E-03	1.25E-03	-5.52E-05	9.15E-06	3.78E-05	1.22E-04	-2.29E-04	-2.82E-04	8.68E-03	-1.63E-05
M2	2.83E-03	9.23E-03	2.32E-03	2.21E-05	-1.04E-05	-5.07E-06	-1.27E-05	-4.51E-05	-6.27E-05	6.68E-03	-1.08E-05
M3	1.25E-03	2.32E-03	7.90E-03	1.02E-04	-8.50E-06	-3.48E-05	-1.66E-04	-2.03E-04	-6.19E-05	4.68E-03	-8.60E-06
PF1	-5.52E-05	2.21E-05	1.02E-04	3.03E-03	4.76E-04	7.20E-05	1.47E-04	1.68E-04	1.19E-04	0.00E+00	8.92E-06
PF2	9.15E-06	-1.04E-05	-8.50E-06	4.76E-04	2.63E-03	4.28E-04	3.22E-04	1.75E-04	1.14E-04	0.00E+00	6.78E-06
PF3	3.78E-05	-5.07E-06	-3.48E-05	7.20E-05	4.28E-04	2.61E-03	1.14E-03	1.82E-04	1.04E-04	0.00E+00	4.40E-06
PF4	1.22E-04	-1.27E-05	-1.66E-04	1.47E-04	3.22E-04	1.14E-03	1.53E-02	1.14E-03	5.90E-04	0.00E+00	1.82E-05
PF5	-2.29E-04	-4.51E-05	-2.03E-04	1.68E-04	1.75E-04	1.82E-04	1.14E-03	1.29E-02	3.49E-03	0.00E+00	4.81E-05
PF6	-2.82E-04	-6.27E-05	-6.19E-05	1.19E-04	1.14E-04	1.04E-04	5.90E-04	3.49E-03	6.26E-03	0.00E+00	3.97E-05
TF	8.68E-03	6.68E-03	4.68E-03	0.00E+00	0.00E+00	0.00E+00	0.00E+00	0.00E+00	0.00E+00	4.90E-02	1.51E-06
Plasma	-1.63E-05	-1.08E-05	-8.60E-06	8.92E-06	6.78E-06	4.40E-06	1.82E-05	4.81E-05	3.97E-05	1.51E-06	2.68E-06

## A.3 Reference Scenario Data

#### A.3.1 Current Waveforms

Conductor currents are given in amperes. Maxima for all reference scenarios are shown in blue, minima in red.

0.5T First Plasma												
Scenario	t(s)	M1	M2	М3	PF1	PF2	PF3	PF4	PF5	PF6	TF	Plasma
	-0.600	0	0	0	0	0	0	0		0	0	0
	0.000	11218	10435	10435	-12877	-12877	-12877	-367		-1223	-1043	0
	0.100	11218	10435	10435	-12877	-12877	-12877	-367		-1223	-1043	0
	0.170	10227	10276	10276	-8144	-8144	-8144	-2774		1125	-325	-35310
	0.265	10227	10276	10276	-4832	-4832	-4832	-1768		1387	-325	-35310
	0.270	10227	10276	10276	-4658	-4658	-4658	-1715		1401	-325	-35310
Maximum		11218	10435	10435	0	0	0	0		1401	0	0
Minimum		0	0	0	-12877	-12877	-12877	-2774		-1223	-1043	-35310
l2t (A2-s)		9.38E+07	8.34E+07	8.43E+07	9.57E+07	9.61E+07	9.97E+07	1.39E+06		9.86E+05	4.36E+06	0
tESW (s)		0.75	0.77	0.77	0.58	0.58	0.60	0.18		0.50	4.01	0

Field Line												
Mapping												
Scenario	t(s)	M1	M2	M3	PF1	PF2	PF3	PF4	PF5	PF6	TF	Plasma
	-0.600	0	0	0				0		0	0	
	0.000	2244	2087	2087				709		-41	-209	
	0.100	2244	2087	2087				709		-41	-209	
	0.200	2244	2087	2087				709		-41	-209	
	2.600	2244	2087	2087				709		-41	-209	
	10.100	2244	2087	2087				709		-41	-209	
Maximum	0	2244	2087	2087				709		0	0	
Minimum	0	0	0	0				0		-41	-209	
I2t (A2-s)	0	5.37E+07	4.64E+07	4.61E+07				5.27E+06		1.67E+04	5.86E+05	
tESW (s)	0	10.66	10.66	10.58				10.50		10.02	13.45	
1.7T Ohmic Scenario	t(s)	M1	M2	М3	PF1	PF2	PF3	PF4	PF5	PF6	TF	Plasma
	-0.700	0	0	0	0	0	0	0	0	0	0	0
	0.000	38141	35504	35453	-25123	-25123	-9698	-7752	8284	-8997	-3548	0
	0.100	38141	35504	35453	-25123	-25123	-9698	-7752	8284	-8997	-3548	0
	0.140	34772	35327	34508	-16185	-16185	-6754	-9327	743	4396	-1106	
	0.240	34772	35327	34508	-12683	-12683	-4812	-7829	766	4609	-1106	
	0.440	34772	35327	34508	-5681	-5681	-928	-4832	814	5033	-1106	-120052
Maximum		38141	35504	35453	0	0	0	0	8284	5033	0	Ũ
Minimum		0	0	0	-25123	-25123	-9698	-9327	0	-8997	-3548	
I2t (A2-s)		1.39E+09	1.29E+09	1.26E+09	4.24E+08	4.30E+08	6.27E+07	4.95E+07	4.61E+07	6.36E+07	1.05E+08	
tESW (s)		0.96	1.02	1.00	0.67	0.68	0.67	0.57	0.67	0.79	8.31	
1.7T High Beta												
Scenario	t(s)	M1	M2	М3	PF1	PF2	PF3	PF4	PF5	PF6	TF	Plasma
	-0.700	0	0	0	0	0	0	0	0	0	0	0
	0.000	38141	35504	35453	-14619	-14619	-3872	-3256	8356	-8360	-3548	0
	0.100	38141	35504	35453	-14619	-14619	-3872	-3256	8356	-8360	-3548	0
	0.140	34772	35327	34508	-5681	-5681	-928	-4832	814	5033	-1106	
	0.240	32795	32587	30018	-6129	-6129	-1953	-7029	2272	6030	3760	
	0.440	32795	32587	30018	-5429	-5429	-1565	-6729	2277	6073	3760	-
Maximum		38141	35504	35453	0	0	0	0	8356	6073	3760	-
Minimum		0	0	0	-14619	-14619	-3872	-7029	0	-8360	-3548	
l2t (A2-s)		1.34E+09	1.22E+09	1.14E+09	1.34E+08	1.36E+08	9.73E+06	3.09E+07	4.73E+07	6.10E+07	1.66E+08	
tESW (s)		0.92	0.96	0.91	0.63	0.63	0.65	0.63	0.68	0.87	11.77	

2T High Beta												
Scenario	t(s)	M1	M2	M3	PF1	PF2	PF3	PF4	PF5	PF6	TF	Plasma
	-0.850	0	0	0	0	0	0	0	0	0	0	0
	0.000	40908	41561	40598	-15274	-15274	-5857	-9362	1080	-24	-1301	0
	0.050	40908	41561	40598	-15274	-15274	-5857	-9362	1080	-24	-1301	0
	0.097	40908	41561	40598	-7612	-7612	-1607	-6082	952	5865	-1301	-141238
	0.192	38583	38338	35315	-8219	-8219	-2857	-8701	2666	7033	4424	-209732
	0.197	38583	38338	35315	-8201	-8201	-2848	-8693	2666	7034	4424	-209732
Maximum		40908	41561	40598	0	0	0	0	2666	7034	4424	0
Minimum		0	0	0	-15274	-15274	-5857	-9362	0	-24	-1301	-209732
l2t (A2-s)		1.51E+09	1.54E+09	1.43E+09	1.68E+08	1.68E+08	2.41E+07	7.08E+07	2.82E+06	7.40E+06	2.25E+08	
tESW (s)		0.90	0.89	0.87	0.72	0.72	0.70	0.81	0.40	0.15	11.50	
1.2T Long Pulse												
Scenario	t(s)	M1	M2	M3	PF1	PF2	PF3	PF4	PF5	PF6	TF	Plasma
	-0.500	0	0	0	0	0	0	0	0	0	0	0
	0.000	26923	25062	25026	-14027	-14027	-4790	-3885	5873	-6126	-2504	0
	0.100	26923	25062	25026	-14027	-14027	-4790	-3885	5873	-6126	-2504	0

-7725

-7939

-2687

-14027

0.54

1.07E+08

0

-7725

-7939

-2687

-14027

0.55

1.08E+08

0

-2716

-3383

-4790

0.53

1.21E+07

-470

0

-5001

-6508

-4260

-6508

1.23

5.19E+07

0

549

1579

1615

5873

0.57

1.97E+07

0

3328

4038

4356

4356

-6126

1.30

4.86E+07

-780

2654

2654

2654

-2504

12.19

8.59E+07

-84743

-125839

-125839

-125839

0

Maximum

Minimum

I2t (A2-s)

tESW (s)

0.128

0.228

1.728

24545

23150

23150

26923

1.33E+09

0

1.83

24937

23003

23003

25062

2.03

1.28E+09

0

24359

21189

21189

25026

1.76

1.10E+09

0

320kA Ohmic												
Scenario	t(s)	M1	M2	M3	PF1	PF2	PF3	PF4	PF5	PF6	TF	Plasma
	-0.600	0	0	0	0	0	0	0	0	0	0	0
	0.000	34772	35327	34508	-22700	-22700	-10368	-12115	852	-610	-1106	0
	0.100	34772	35327	34508	-22700	-22700	-10368	-12115	852	-610	-1106	0
	0.206	34200	32057	32184	11354	11354	-11802	-13936	4563	5068	2191	-320775
	0.306	34200	32057	32184	14855	14855	-9860	-12438	4587	5280	2191	-320775
	0.506	34200	32057	32184	21858	21858	-5975	-9441	4634	5705	2191	-320775
Maximum		34772	35327	34508	21858	21858	0	0	4634	5705	2191	0
Minimum		0	0	0	-22700	-22700	-11802	-13936	0	-610	-1106	-320775
l2t (A2-s)		1.25E+09	1.18E+09	1.14E+09	4.14E+08	4.04E+08	9.10E+07	1.37E+08	1.04E+07	1.17E+07	1.32E+08	
tESW (s)		1.04	0.94	0.96	0.80	0.78	0.65	0.71	0.48	0.36	27.43	
Ref. Scenario												
Summary		M1	M2	M3	PF1	PF2	PF3	PF4	PE5	PF6	TF	Plasma

Ref. Scenario											
Summary	M1	M2	M3	PF1	PF2	PF3	PF4	PF5	PF6	TF	Plasma
Maximum	40908	41561	40598	21858	21858	0	709	8356	7034	4424	0
Minimum	0	0	0	-25123	-25123	-12877	-13936	0	-8997	-3548	-320775
Max I2t (A2-s)	1.51E+09	1.54E+09	1.43E+09	4.24E+08	4.30E+08	9.97E+07	1.37E+08	4.73E+07	6.36E+07	2.25E+08	
tESW (s) at max											
current	0.90	0.89	0.87	0.67	0.68	0.60	0.71	0.68	0.79	11.50	

# A.3.2 Temperature History

Coil temperatures are in Kelvin. Maxima for all reference scenarios are shown in blue.

# A.3.2.1 Temperature History For Room Temperature Operation

0.5T First											
Plasma											
Scenario	t(s)	M1	M2	M3	PF1	PF2	PF3	PF4	PF5	PF6	TF
	-0.600	295	295	295	295	295	295	295	295	295	295
	0.000	299	299	299	298	298	298	295	295	295	295
	0.100	300	300	300	299	299	299	295	295	295	295
	0.170	301	300	300	299	299	299	295	295	295	295
	0.265	302	301	301	299	299	299	295	295	295	295
	0.270	302	301	301	299	299	299	295	295	295	295
	0.948	303	302	302	299	299	300	295	295	295	295
Dissipated											
Energy (J)		5.99E+06	5.21E+06	4.37E+06	9.68E+05	9.73E+05	1.01E+06	3.81E+04	1.43E+03	2.40E+04	3.35E+05
											1.89E+07

Field Line Mapping											
Scenario	t(s)	M1	M2	M3	PF1	PF2	PF3	PF4	PF5	PF6	TF
	-0.600	328	328	328	328	328	328	328	328	328	328
	0.000	328	328	328	328	328	328	328	328	328	328
	0.100	328	328	328	328	328	328	328	328	328	328
	0.200	328	328	328	328	328	328	328	328	328	328
	2.600	329	329	329	328	328	328	328	328	328	328
	10.100	333	332	332	328	328	328	328	328	328	328
	10.778	333	332	332	328	328	328	328	328	328	328
Dissipated											
Energy (J)		3.90E+06	3.30E+06	2.72E+06	3.41E+00	1.37E+00	3.39E+01	1.62E+05	4.22E+00	4.67E+02	5.11E+04
											1.01E+07

Summary	M1	M2	M3	PF1	PF2	PF3	PF4	PF5	PF6	TF
Max Final										
Temperature	333	332	332	328	328	328	328	328	328	328
Max Dissipated										
Energy (J)	5.99E+06	5.21E+06	4.37E+06	9.68E+05	9.73E+05	1.01E+06	1.62E+05	1.43E+03	2.40E+04	3.35E+05
										1.89E+07

## A.3.2.2 Temperature History For LN2 Operation

1.7T Ohmic											
Scenario	t(s)	M1	M2	M3	PF1	PF2	PF3	PF4	PF5	PF6	TF
	-0.700	85	85	85	85	85	85	85	85	85	85
	0.000	97	95	96	88	89	86	85	85	86	85
	0.100	100	98	98	89	89	86	85	85	86	85
	0.140	101	99	100	89	89	86	85	86	86	85
	0.240	104	102	103	90	90	86	85	86	86	85
	0.440	111	109	109	90	90	86	85	86	86	85
	3.621	119	116	115	90	90	86	86	86	86	86
Dissipated											
Energy (J)		1.82E+07	1.61E+07	1.29E+07	6.22E+05	6.31E+05	8.62E+04	1.82E+05	2.13E+05	2.12E+05	1.11E+06
											5.03E+07
											5.03E+07
1.7T High Beta											5.03E+07
1.7T High Beta	t(s)	M1	M2	М3	PF1	PF2	PF3	PF4	PF5	PF6	5.03E+07
	<b>t(s)</b> -0.700	M1 85	<b>M2</b> 85	<b>M3</b> 85	<b>PF1</b> 85	<b>PF2</b> 85	<b>PF3</b> 85	<b>PF4</b> 85	<b>PF5</b> 85	<b>PF6</b> 85	
1.7T High Beta				-			-		-	-	TF
1.7T High Beta	-0.700	85	85	85	85	85	85	85	85	85	<b>TF</b> 85
1.7T High Beta	-0.700 0.000	85 97	85 95	85 96	85 86	85 86	85 85	85 85	85 85	85 85	<b>TF</b> 85 85
1.7T High Beta	-0.700 0.000 0.100	85 97 100	85 95 98	85 96 98	85 86 86	85 86 86	85 85 85	85 85 85	85 85 85	85 85 86	<b>TF</b> 85 85 85
1.7T High Beta	-0.700 0.000 0.100 0.140	85 97 100 101	85 95 98 99	85 96 98 100	85 86 86 86	85 86 86 86	85 85 85 85	85 85 85 85	85 85 85 86	85 85 86 86	TF 85 85 85 85 85 85 85 85
1.7T High Beta	-0.700 0.000 0.100 0.140 0.240	85 97 100 101 104	85 95 98 99 102	85 96 98 100 102	85 86 86 86 86	85 86 86 86 86	85 85 85 85 85 85	85 85 85 85 85	85 85 85 86 86	85 85 86 86 86	TF 85 85 85 85 85 85
1.7T High Beta	-0.700 0.000 0.100 0.140 0.240 0.440	85 97 100 101 104 110	85 95 98 99 102 107	85 96 98 100 102 107	85 86 86 86 86 86	85 86 86 86 86 86	85 85 85 85 85 85 85	85 85 85 85 85 85	85 85 85 86 86 86	85 85 86 86 86 86	TF 85 85 85 85 85 85 85 85

1.78E+06 4.61E+07

2T High Beta											
Scenario	t(s)	M1	M2	M3	PF1	PF2	PF3	PF4	PF5	PF6	TF
	-0.850	85	85	85	85	85	85	85	85	85	85
	0.000	104	106	105	87	87	85	85	85	85	85
	0.050	106	108	107	87	87	85	85	85	85	85
	0.097	108	110	109	87	87	85	85	85	85	85
	0.192	112	114	113	87	87	85	86	85	85	85
	0.197	112	114	113	87	87	85	86	85	85	85
	3.378	122	123	120	87	87	85	86	85	85	87
Dissipated											
Energy (J)		2.04E+07	2.05E+07	1.53E+07	2.35E+05	2.35E+05	3.28E+04	2.63E+05	1.37E+04	2.63E+04	2.43E+06
		-									5.95E+07

.2T Long Pulse											
Scenario	t(s)	M1	M2	M3	PF1	PF2	PF3	PF4	PF5	PF6	TF
	-0.500	85	85	85	85	85	85	85	85	85	8
	0.000	88	88	88	86	86	85	85	85	85	8
	0.100	90	89	89	86	86	85	85	85	85	8
	0.128	90	90	90	86	86	85	85	85	85	8
	0.228	92	91	91	86	86	85	85	85	85	8
	1.728	113	112	108	86	86	85	86	85	86	8
	4.909	117	115	111	86	86	85	86	85	86	8
Dissipated											
Energy (J)		1.71E+07	1.58E+07	1.08E+07	1.49E+05	1.50E+05	1.66E+04	1.94E+05	9.14E+04	1.64E+05	9.11E+0
								-			1.01E+0

320kA Ohmic											
Scenario	t(s)	M1	M2	M3	PF1	PF2	PF3	PF4	PF5	PF6	TF
	-0.600	85	85	85	85	85	85	85	85	85	85
	0.000	93	93	93	87	87	85	85	85	85	85
	0.100	95	96	96	88	88	86	86	85	85	85
	0.206	98	99	98	88	88	86	86	85	85	85
	0.306	101	101	101	88	88	86	86	85	85	85
	0.506	107	106	106	89	89	86	86	85	85	85
	3.687	115	113	112	90	90	86	87	85	85	86
Dissipated											
Energy (J)		1.59E+07	1.43E+07	1.13E+07	6.22E+05	6.04E+05	1.27E+05	5.18E+05	5.04E+04	4.02E+04	1.40E+06
											4.48E+07

Summary	M1	M2	M3	PF1	PF2	PF3	PF4	PF5	PF6	TF
Max Final										
Temperature	122	123	120	90	90	86	87	86	86	87
Max Dissipated										
Energy (J)	2.04E+07	2.05E+07	1.53E+07	6.22E+05	6.31E+05	1.27E+05	5.18E+05	2.19E+05	2.12E+05	2.43E+06
										5.95E+07

#### A.3.3 Electrical Power Requirements

#### A.3.3.1 Power Supply and Cabling Requirements and Modeling Assumptions

Power supply requirements for the reference scenarios have been calculated based on the following assumptions:

- [1] All coils of the same type (e.g. all M1 coils) are connected in series. All coils in the same circuit are connected in series. Circuit configurations are defined in the table below.
- [2] All coils of the same type have a single CLR connected in series with the coils. Each CLR has an inductance of 267 micro-H and a resistance of 100 milli-ohms.
- [3] DC power will be carried from D-site to the test cell via cables approximately 750 feet in length (each way). Required DC current ratings and cables per pole in each circuit are defined in the table below. An inductance of 132 micro-Henries per cable pair (supply and return) was assumed.
- [4] TFTR power supply sections (PSS) will be used. Each PSS has an open circuit voltage of 1012.85V and a maximum current of 28kA. When operated in parallel, the maximum rated current is reduced by 10%.
- [5] Required DC ratings are based on a pulse repetation time of 15 minutes.

# Changes in the capability required are shown in red

Description	Scenarios	Circuit 1	Circuit 2	Circuit 3	Circuit 4	Circuit 5	Circuit 6	Circuit 7	Circuit 8	Circuit 9	Circuit 10	Total
Initial capability	First Plasma		M2,M3	PF1/2/3								
required	FL Mapping	M1	M2	M3	PF4	PF6	TF					
37 MW	Max I2t (A2-s)	9.38E+07	8.43E+07	9.97E+07	5.27E+06	9.86E+05	4.36E+06					
88 MVA	tESW (s)	0.75	0.77	0.60	0.69	0.50	4.01					
	Required DC											
25 MJ	rating (A)	323	306	333	77	33	70					
	Cables per pole	1	1	1	1	1	1					12 Cables
	Series PSS per											
	branch	2	2	2	2	2	2					14 PSS
	Branches	1	1	1	1	2	1					
	Branch					Anti-						
	configuration					parallel						
	1.7T Ohmic											
	1.7T Hi Beta											
Ultimate	2T Hi Beta											
capability	1.2T Long Pulse											
required	320kA	M1	M2	M3	PF4	PF6	TF	PF1/2	PF3	PF5U	PF5L	
154 MW	Max I2t (A2-s)	1.51E+09	1.54E+09	1.43E+09	1.37E+08	6.36E+07	2.25E+08	4.30E+08	9.10E+07	4.73E+07	4.73E+07	
408 MVA	tESW (s)	0.90	0.89	0.87	0.71	0.79	11.50	0.68	0.65	0.68	0.68	
	Required DC											
124 MJ	rating (A)	1296	1308	1262	391	266	500	691	318	229	229	
	Cables per pole	2	2	2	1	1	1	1	1	1	1	26 Cables
	Series PSS per											
	branch	2	2	2	2	2	4	4	2	2	2	40 PSS
	Branches	2	2	2	1	2	2	2	1	1	1	
	Branch	Parallel	Parallel	Parallel		Anti-	Anti-	Anti-				
	configuration					parallel	parallel	parallel				

## A.4 Cryogenic System Requirements

#### A.4.1 Pulsed Heat Loads

Pulsed heat loads for the modular coils calculated on a temperature rise from 85K to 125K in each modular coil. Pulsed heat loads for the TF and PF coils calculated on the basis of the worst case scenario for each coil. Total heat loads calculated by summing the above.

Pulsed heat Loads	M1	M2	M3	PF1	PF2	PF3	PF4	PF5	PF6	TF
Initial Temperature (K)	85	85	85	85	85	85	85	85	85	85
Max Temperature (K)	122	123	120	90	90	86	87	86	86	87
Energy Deposited (J)	2.04E+07	2.05E+07	1.53E+07	6.22E+05	6.31E+05	1.27E+05	5.18E+05	2.19E+05	2.12E+05	2.43E+06
										5.95E+07

					Mass per	Density		Volume		
LN2 Consumption		Tsat (K)	Psat (MPa)	hfg (kJ/kg)	pulse (kg)	(kg/m3)	(m3/kg)	(m3)	(liters)	(gallons)
Per shot		78	0.1093654	198.3014	299.92697	805.73502	0.0012411	0.3722402	372.24021	98 per shot
Time between shots (minutes)	15									
Hours per day	8									
Full pwr shots per day	32									3147 per day
Operating days per week	5									15734 per wk

### A.4.2 Parasitic Heat Loads

Г

Heat leakages to the cold mass calculated on the basis of numbers provided by cognizant engineers based on nominal VV operating temperatures of 40C and bakeout temperatures of 150C with the cold mass at 80K.

Normal Operation	Heat Load (kW)	Flow rate (kg/s)	Vol flow rate (m3/s)	s/week	Volume (m3)	(liters)	(gallons)
Cryostat GN2 circulation	9.1						
Modular coil LN2 cooling	5.4						
Heat removed at cryo temperature	14.5	0.073121	9.075E-05	604800	54.886022	54886.022	14499 per wk

Bakeout	Heat Load (kW)		Vol flow rate (m3/s)	s/week	Volume (m3)	(liters)	(gallons)
Cryostat GN2 circulation Modular coil LN2 cooling	12.4 8.7						
Heat removed at cryo temperature	21.0	0.1060519	0.0001316	604800	79.604538	79604.538	21029 per wk

## A.4.3 Heat Loads For Cooling the Cold Mass from RT to 80K

 Cold mass
 75000 kg

 Cryogen requirements
 0.43 kg of LN2 per kg of SS assuming evaporation enthalpy only

 32250 kg based on evaporation enthalpy only

 10574 gallons

# A.4.4 LN2 Delivery Requirements

	gallons per truck	trucks
Pulsed heat loads only	6500	2.4 per week
Parasitic loads only		
Normal		2.2 per week
Bakeout		3.2 per week
Cooldown only		1.6

# **Appendix B – Characteristic Allocation Matrix**

3.2.1	stics Allocation Matrix Performance Characteristics	11 - In-Vessel Components	12 - Vacuum Vessel Systems	13 - Conventional Coils	14 - Modular Coils	15 - Structures	17 - Cryostat and Base Support Structure	21/23 - Fueling and Wall Conditioning	22 - Torus Vacuum Pumping	24 - Ion Cyclotron Heating System	25 - Neutral Beam Injection System	26 - Electron Cyclotron Heating System	3 - Diagnostics	4 - Electrical Power Systems	5 - Central I&C Systems	61 - Water Cooling Systems	62 - Cryogenic Systems	63 - Utility Systems	64 - Helium Bakeout System	7 - Test Cell Preparation and Machine Assy
3.2.1.1	Initial Facility Startup	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х
3.2.1.2	Pre-Run Facility Startup	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х
3.2.1.2.1	Coil Cool-down																			
3.2.1.2.1.1	Coil Cool-down Timeline			Х	Х	Х	Х										Х			$\square$
3.2.1.2.1.2	Cool-down and Warm-up Cycles	N N	V	Х	Х	Х	Х	X		V		V	V				Х		X	
3.2.1.2.1.3	Pre-Run Temperatures	Х	Х					Х		Х		Х	Х						Х	
3.2.1.2.2	Vacuum Requirements		V		_			V	V	V	V	V	V		_			_		
3.2.1.2.2.1	Base Pressure	Х	Х					Х	X	Х	Х	Х	Х							$\vdash$
3.2.1.2.2.2	Pumping Speed		Х						Х											
3.2.1.2.3	Bakeout		V				_								_			_	V	_
3.2.1.2.3.1	Vacuum Vessel Bakeout Temperatures Carbon-based Plasma Facing		Х																Х	<u> </u>
3.2.1.2.3.2	Components (PFCs) Bakeout Temperatures	x	x																х	
3.2.1.2.3.3	Coil Temperatures During Bakeout			Х	Х	Х	Х										Х			
3.2.1.2.3.4	Bakeout Timelines Glow Discharge Cleaning (GDC) During	Х	Х					Х	Х	Х		Х	Х						Х	
3.2.1.2.3.5	Bakeout	Х	Х					Х	х	Х	х	Х	Х						Х	
3.2.1.2.3.6	Bakeout Cycles	Х	Х					Х	Х	Х		Х	Х						Х	
	Pre-operational Initialization and																			
3.2.1.3	Verification	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	х
3.2.1.3.1	Plasma Chamber Conditioning																			
3.2.1.3.1.1	Boronization	Х	X X					Х	X X X	Х	Х	Х	Х							
	Lithiumization	Х	Х					Х	Х	Х	Х	Х	Х							
3.2.1.4	Pre-pulse Initialization and Verification	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х
	Glow Discharge Cleaning (GDC)																			
3.2.1.4.1	Between Pulses	Х	Х						Х		Х		Х						Х	
3.2.1.4.2	Pre-Pulse Temperature	Х	Х					Х	Х	Х		Х	Х						Х	
3.2.1.5	Experimental Operations		, <i>,</i> ,	, <i>i</i>			<u>, /</u>									, <i>i</i>				
3.2.1.5.1	Field Error Requirements	X	X	Х		Х	Х	Х	Х		Х		X	Х	Х	Х	Х	Х	Х	X
3.2.1.5.2	Electrical (Eddy Current) Requirements	Х	Х	Х	Х	Х	Х	Х		Х		Х	Х							Х
3.2.1.5.3	Plasma Magnetic Field Requirements				V	V	V		V	V	V	V	V	V	V		V	V	V	$\overline{\mathbf{v}}$
3.2.1.5.3.1 3.2.1.5.3.2	Coordinate System Magnetic Field Polarity	X X	X X	X X	X X	X X	X X	X X	Х		× ×	X X	× ×	X X		Х	Х	Х	Х	Х
3.2.1.5.3.2	Reference Scenarios	^	^	^	^	^	^	^		^	^	^	^	^	^					
3.2.1.5.3.3.1	Reference Scenario Specifications																			
3.2.1.5.3.3.1.1	First Plasma Scenario	Х	Х	Х	Х	Х								Х			Х		Х	
	Field Line Mapping Scenario	X	X		X	X			-					X			X		X	
	1.7T Ohmic Scenario	$\uparrow$				X			-					X			X		X	
	1.7T High Beta Scenario	-	X	X	X	X			-					X			X		X	
	1.2T High Beta Long-Pulse Scenario	-	X	X	X	X			-					X			X		X	
0.Z. 1.0.0.0 1.0																				

	istics Allocation Matrix 320 kA Ohmic Scenario	11 - In-Vessel Components	× 12 - Vacuum Vessel Systems	× 13 - Conventional Coils	× 14 - Modular Coils	× 15 - Structures	17 - Cryostat and Base Support Structure	21/23 - Fueling and Wall Conditioning	22 - Torus Vacuum Pumping	24 - Ion Cyclotron Heating System	25 - Neutral Beam Injection System	26 - Electron Cyclotron Heating System	3 - Diagnostics	× 4 - Electrical Power Systems	5 - Central I&C Systems	61 - Water Cooling Systems	imes 62 - Cryogenic Systems	63 - Utility Systems	imes 64 - Helium Bakeout System	7 - Test Cell Preparation and Machine Assy
3.2.1.5.3.3.2	Reference Scenario Requirements		Х	Х	Х	Х								Х			Х		Х	
3.2.1.5.3.4	Flexibility Requirements																			
3.2.1.5.3.4.1	Quasi-axisymmetry Flexibility		Х	Х	Х	Х								Х				H	Х	
3.2.1.5.3.4.2	External lota Flexibility	-	X	X	X	X	-							X		$\square$	$\square$	$\vdash$	X	
3.2.1.5.3.4.3	Shear Flexibility	-	X	X	X	X	-							X		$\vdash$		$\vdash$	X	
3.2.1.5.3.4.4	Beta Limit Flexibility		X	X	X	X								X				$\vdash$	X	
3.2.1.5.3.4.5	Radial and Vertical Position Flexibility		X	X	X	X								X			<u> </u>		X	
3.2.1.5.3.4.5	Equilibrium Control		^	X	^	^							Х	^ X	Х				^	
			$\vdash$		V	V							~		~		$\vdash$		$\vdash$	
3.2.1.5.3.6	Breakdown Loop Voltage			Х	Х	Х							V	Х			$\vdash$		$\square$	<b></b>
3.2.1.5.3.7	Power Supply Ripple			<u> </u>									Х	Х					$\square$	<b></b>
3.2.1.5.3.8	Coil Current Measurements												Х	Х					$\square$	
3.2.1.5.4	Power Handling																			
3.2.1.5.4.1	PFC Configuration	Х	Х					Х	Х				Х						Х	
3.2.1.5.4.2	Maximum Plasma Heating Power	Х	Х							Х	Х	Х							Х	
	Maximum Component Surface																			
3.2.1.5.4.3	Temperature	Х																		
3.2.1.5.5	Disruption Handling	Х	Х	Х	Х	Х														
3.2.1.5.6	Plasma Heating																			
3.2.1.5.6.1	Neutral Beam Heating																			
	0																			
3.2.1.5.6.1.1	Initial Neutral Beam Heating Complement										Х			Х		Х	х			Х
	Ultimate Neutral Beam Heating																			
3.2.1.5.6.1.2	Complement										х			х		x	х			x
	Ion Cyclotron Heating (ICH)		Х							Х	~			X		X X	~			X X
3.2.1.5.6.3	Electron Cyclotron Heating (ECH)		~							~		Х		X		X				X
3.2.1.5.7	Plasma Fueling								_			~								
3.2.1.5.7.1	Fuel Species							Х	Х	Y	Y	Y								
3.2.1.5.7.2	Gas Injection		$\vdash$	<u> </u>				X	^	^	^	^		⊢┥		$\vdash$	$\vdash$	$\vdash$	⊢	
3.2.1.5.7.3	Pellet Injection	Х	Х					X						┢──┤		$ \rightarrow $	$\vdash$	$\vdash$	┢──┤	
		^						^												
3.2.1.5.8	Plasma Diagnostics			-									V							
3.2.1.5.8.1	General Diagnostics Requirements		$\vdash$										Х	$\vdash$			⊢	$\vdash$	┢──┤	<b></b>
3.2.1.5.8.2	Diagnostics Implementation		$\vdash$	┣—									Х			$\square$	⊢	$\square$	$\vdash$	
	Instrumentation, Control, and Data															1				
3.2.1.5.9	Acquisition	, <i>,</i> ,	Ļ	<u> </u>	, <i>,</i> ,	, <i>i</i>	, <i>,</i> ,	<u>,                                     </u>							Х				Ļ	
3.2.1.5.10	Pulse Repetition Rate	Х	Х	Х	Х	Х	Х	X	Х	Х	Х	Х	Х	Х	Х	Х	Х	X	Х	Х
3.2.1.5.11	Discharge Termination			<u> </u>																
3.2.1.5.11.1	Normal Termination	Х	Х	Х	Х	Х	Х	Х	Х		Х	Х	Х	Х	Х	Х	Х	Х	Х	Х
3.2.1.5.11.2	Abnormal Termination	Х	Х	Х	Х	Х	Х	Х	Х						Х		Х		Х	
1	Facility Shutdown	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	Х	X	Х	Х
3.2.1.6			~											<u> </u>				~		
3.2.1.6 3.2.1.6.1	Coil Warm-up Timeline			X	X	X	X							Ê			X		Ê	

**Appendix C – Quality Conformance Matrix** 

# Key: X = Before First Plasma Y= After First Plasma

		1	1	-	1		Key: X = before First Plasma T = After First Plasma
		ç		Demonstration		Not Applicable	
		Examination		trat		lica	
		lin		Suc	Analysis	ddv	
	<b>. .</b>	αn	Test	Ĩ,	lal	ot A	
	onformance Matrix	ш	۳	ă	Ā	ž	Remarks
3.2.1	Performance Characteristics			X			
3.2.1.1	Initial Facility Startup			X			
3.2.1.2 3.2.1.2.1	Pre-Run Facility Startup Coil Cool-down			Х		_	
3.2.1.2.1							First few cooldowns should be closely monitored to assure
							that temperatures are tracking expected values and that no
							unanticipated thermal stresses are being imposed. Ultimate
3.2.1.2.1.1	Coil Cool-down Timeline			Y			demonstration after First Plasma.
3.2.1.2.1.2	Cool-down and Warm-up Cycles				Х		
3.2.1.2.1.3	Pre-Run Temperatures			Х	~		
3.2.1.2.2	Vacuum Requirements						
0.2.1.2.2							
							Historically, it takes time to initially eliminate all vacuum leaks
							and to condition the vacuum vessel adequately for UHV
							conditions. The PEP requires the following at First Plasma:
							[1] A base pressure of $2 \times 10^{-7}$ torr and [2] a maximum global
							leak rate of $<1\times10^{-4}$ torr-l/s. These values are higher than the
221224	Base Pressure			Y			ultimate requirements of $2x10^{-8}$ torr and $2x10^{-5}$ torr-l/s.
3.2.1.2.2.1 3.2.1.2.2.2			х	Ŷ			
3.2.1.2.2.2	Pumping Speed Bakeout		^				
3.2.1.2.3.1	Vacuum Vessel Bakeout Temperatures			Х			
5.2.1.2.5.1	Carbon-based Plasma Facing			^			
	Components (PFCs) Bakeout						
3.2.1.2.3.2	Temperatures				х		Upgrade requirement
3.2.1.2.3.3	Coil Temperatures During Bakeout			Х	~		
0.2.1.2.0.0				~			First few bakeouts should be closely monitored to assure that
							temperatures are tracking expected values and that no
							unanticipated thermal stresses are being imposed. Ultimate
3.2.1.2.3.4	Bakeout Timelines			Y			demonstration after First Plasma.
	Glow Discharge Cleaning (GDC) During						
3.2.1.2.3.5	Bakeout			Х			
3.2.1.2.3.6	Bakeout Cycles				Х		
	Pre-operational Initialization and						
3.2.1.3	Verification			Х			
3.2.1.3.1	Plasma Chamber Conditioning						
3.2.1.3.1.1	Boronization				Х		Upgrade requirement
3.2.1.3.1.2	Lithiumization				Х		Upgrade requirement
3.2.1.4	Pre-pulse Initialization and Verification			Х			
	Glow Discharge Cleaning (GDC) Between	~					
3.2.1.4.1	Pulses	Х					
2 2 4 4 2	Bro Buloo Tomporaturo		1	-	b		
3.2.1.4.2	Pre-Pulse Temperature			а	С		
3.2.1.5	Experimental Operations			h			Part b domonstrated during Field Line Manning (Decce II)
3.2.1.5.1 3.2.1.5.2	Field Error Requirements Electrical (Eddy Current) Requirements	а	<u> </u>	b	х		Part b demonstrated during Field Line Mapping (Phase II)
3.2.1.5.2	Plasma Magnetic Field Requirements						
3.2.1.5.3.1	Coordinate System					Х	
3.2.1.5.3.2	Magnetic Field Polarity	b		а		~	
3.2.1.5.3.3	Reference Scenarios	0		a			
3.2.1.5.3.3.1	Reference Scenario Specifications						
3.2.1.5.3.3.1.1						Х	
3.2.1.5.3.3.1.2			1			X	
3.2.1.5.3.3.1.3			1			X	
3.2.1.5.3.3.1.4	1.7T High Beta Scenario		1			X	
	1.2T High Beta Long-Pulse Scenario		1			Х	
	2T High Beta Scenario		1			Х	
	320 kA Ohmic Scenario		1			Х	
						-	

Guality Conformance Matrix         is         is <th< th=""></th<>
All coil systems should be tested at their full circuit rating prior to First Plasma. (The PEP has less stringent requirements.) Deflections and temperatures should be enclosed on those systems were behavas as expected.         Electrical power (including real time control) and cryoger systems should be tested prior to First Plasma to show those systems were operating at their rated capacity whi would meet the requirements of the First Plasma actional demonstrate that the integrated requirements for the First Plasma Scenarios.         3.2.1.5.3.2       Reference Scenario Requirements       X         3.2.1.5.3.4       Flexibility Requirements       X         3.2.1.5.3.4.1       Flexibility Requirements       X         3.2.1.5.3.4.2       External lota Flexibility       X         3.2.1.5.3.4.3       Breakdown Loop Voltage       X         3.2.1.5.3.4.5       Radial and Vertical Position Flexibility       X         3.2.1.5.3.4       Power Supply Ripple       X         3.2.1.5.3.4.5       Power Handling       X         3.2.1.5.3.4.7       Power Handling       X         3.2.1.5.3.4.8       Temperature       X         3.2.1.5.3.4       Power Handling       X         3.2.1.5.3.4       Readial and Vertical Position Flexibility       X         3.2.1.5.4.1       Power Handling       X         3.2.1.5.4.1       Power Handling       X
3.2.1.5.3.3.2       Reference Scenario Requirements       X       phases of operation.         3.2.1.5.3.4.1       Guasi-axisymmetry Flexibility       X       state of the state of
3.2.1.5.3.4       Flexibility Requirements       X         3.2.1.5.3.4.1       Quasi-axisymmetry Flexibility       X         3.2.1.5.3.4.2       External lota Flexibility       X         3.2.1.5.3.4.3       Shear Flexibility       X         3.2.1.5.3.4.4       Beta Limit Flexibility       X         3.2.1.5.3.4.5       Radial and Vertical Position Flexibility       X         3.2.1.5.3.4.5       Radial and Vertical Position Flexibility       X         3.2.1.5.3.6       Breakdown Loop Voltage       X         3.2.1.5.3.7       Power Supply Ripple       X         3.2.1.5.3.8       Coil Current Measurements       X         3.2.1.5.4       Power Handling       a         a.2.1.5.4       Power Handling       a         3.2.1.5.4.1       PFC Configuration       b       f         3.2.1.5.4.2       Maximum Plasma Heating Power       X         3.2.1.5.4.3       Temperature       X         3.2.1.5.5       Disruption Handling       X         3.2.1.5.6       Plasma Heating       X         3.2.1.5.6.1       Neutral Beam Heating       X         3.2.1.5.6.1       Neutral Beam Heating       X         3.2.1.5.6.1       Neutral Beam Heating       X
3.2.1.5.3.4.1       Quasi-axisymmetry Flexibility       X         3.2.1.5.3.4.2       External lota Flexibility       X         3.2.1.5.3.4.3       Shear Flexibility       X         3.2.1.5.3.4.4       Beta Limit Flexibility       X         3.2.1.5.3.4.5       Radial and Vertical Position Flexibility       X         3.2.1.5.3.4.5       Radial and Vertical Position Flexibility       X         3.2.1.5.3.6       Breakdown Loop Voltage       X         3.2.1.5.3.7       Power Supply Ripple       X         3.2.1.5.3.8       Coil Current Measurements       X         3.2.1.5.4       Power Handling       a         c       a       c         3.2.1.5.4.1       PFC Configuration       b       f         3.2.1.5.4.2       Maximum Plasma Heating Power       X         3.2.1.5.4.3       Temperature       X         3.2.1.5.4.3       Temperature       X         3.2.1.5.6       Disruption Handling       X         3.2.1.5.6       Neutral Beam Heating       First Plasma:         3.2.1.5.6.1       Neutral Beam Heating       First Plasma:         3.2.1.5.6.1       Neutral Beam Heating       First Plasma:         3.2.1.5.6.1       Neutral Beam Heating       Fi
3.2.1.5.3.4.2       External lota Flexibility       X         3.2.1.5.3.4.3       Shear Flexibility       X         3.2.1.5.3.4.4       Beta Limit Flexibility       X         3.2.1.5.3.4.5       Radial and Vertical Position Flexibility       X         3.2.1.5.3.4.5       Radial and Vertical Position Flexibility       X         3.2.1.5.3.4.5       Radial and Vertical Position Flexibility       X         3.2.1.5.3.6       Breakdown Loop Voltage       X         3.2.1.5.3.7       Power Supply Ripple       X         3.2.1.5.3.8       Coil Current Measurements       X         3.2.1.5.4       Power Handling       a         a       c       c         3.2.1.5.4.1       PFC Configuration       b         maximum Component Surface       x         3.2.1.5.4.1       PFC Configuration       x         3.2.1.5.5       Disruption Handling       X         3.2.1.5.6       Plasma Heating       X         3.2.1.5.6.1       Neutral Beam Heating       X         3.2.1.5.6.1       Ne
3.2.1.5.3.4.3       Shear Flexibility       X         3.2.1.5.3.4.4       Beta Limit Flexibility       X         3.2.1.5.3.4.5       Radial and Vertical Position Flexibility       X         3.2.1.5.3.5       Equilibrium Control       X         3.2.1.5.3.6       Breakdown Loop Voltage       X         3.2.1.5.3.7       Power Supply Ripple       X         3.2.1.5.3.8       Coil Current Measurements       X         3.2.1.5.4       Power Handling       A         3.2.1.5.4.1       PFC Configuration       b       f         3.2.1.5.4.2       Maximum Plasma Heating Power       X         3.2.1.5.4.3       Temperature       X         3.2.1.5.5       Disruption Handling       X         3.2.1.5.6.1       Neutral Beam Heating       X         3.2
3.2.1.5.3.4.4       Beta Limit Flexibility       X         3.2.1.5.3.4.5       Radial and Vertical Position Flexibility       X         3.2.1.5.3.5       Equilibrium Control       X         3.2.1.5.3.6       Breakdown Loop Voltage       X         3.2.1.5.3.7       Power Supply Ripple       X         3.2.1.5.3.8       Coil Current Measurements       X         3.2.1.5.4       Power Handling       a         a.2.1.5.4.1       PFC Configuration       b       f         3.2.1.5.4.2       Maximum Plasma Heating Power       X         Maximum Component Surface       X       3.2.1.5.5         3.2.1.5.6       Disruption Handling       X         3.2.1.5.6       Plasma Heating       X         3.2.1.5.6.1       Neutral Beam Heating       X <t< td=""></t<>
3.2.1.5.3.4.5       Radial and Vertical Position Flexibility       X         3.2.1.5.3.5       Equilibrium Control       X         3.2.1.5.3.6       Breakdown Loop Voltage       X         3.2.1.5.3.7       Power Supply Ripple       X         3.2.1.5.3.8       Coil Current Measurements       X         3.2.1.5.4       Power Handling       a         3.2.1.5.4       Power Handling       a         3.2.1.5.4.1       PFC Configuration       b       f         3.2.1.5.4.2       Maximum Plasma Heating Power       X         3.2.1.5.4.3       Temperature       X         3.2.1.5.5       Disruption Handling       X         3.2.1.5.5       Disruption Handling       X         3.2.1.5.6       Plasma Heating       X         3.2.1.5.6.1       Neutral Beam Heating       X         3.2.1.5.6.1 <t< td=""></t<>
3.2.1.5.3.5       Equilibrium Control       X         3.2.1.5.3.6       Breakdown Loop Voltage       X         3.2.1.5.3.7       Power Supply Ripple       X         3.2.1.5.3.8       Coil Current Measurements       X         3.2.1.5.4       Power Handling       X         3.2.1.5.4.1       PFC Configuration       b       f         3.2.1.5.4.2       Maximum Plasma Heating Power       X         Maximum Component Surface       X         3.2.1.5.5       Disruption Handling       X         3.2.1.5.6       Plasma Heating       X         3.2.1.5.6       Plasma Heating       X         3.2.1.5.6.1       Neutral Beam Heating
3.2.1.5.3.6       Breakdown Loop Voltage       X         3.2.1.5.3.7       Power Supply Ripple       X         3.2.1.5.3.8       Coil Current Measurements       X         3.2.1.5.4       Power Handling       a         3.2.1.5.4.1       PFC Configuration       b       f         3.2.1.5.4.1       PFC Configuration       b       f         3.2.1.5.4.2       Maximum Plasma Heating Power       X       x         3.2.1.5.4.3       Temperature       X       x         3.2.1.5.4.3       Temperature       X       x         3.2.1.5.6       Plasma Heating       X       x         3.2.1.5.6.1       Neutral Beam Heating       x       x         A       Beam
3.2.1.5.3.7       Power Supply Ripple       X         3.2.1.5.3.8       Coil Current Measurements       X         3.2.1.5.4       Power Handling       a         3.2.1.5.4       Power Handling       a         3.2.1.5.4       Power Handling       a         3.2.1.5.4       Power Handling       a         3.2.1.5.4       PFC Configuration       b       f         3.2.1.5.4.1       PFC Configuration       b       f         3.2.1.5.4.2       Maximum Plasma Heating Power       X         Maximum Component Surface       X         3.2.1.5.4.3       Temperature       X         3.2.1.5.6       Disruption Handling       X         3.2.1.5.6       Plasma Heating       X         3.2.1.5.6.1       Neutral Beam Heating       X
3.2.1.5.3.8       Coil Current Measurements       X         3.2.1.5.4       Power Handling       a         3.2.1.5.4       PFC Configuration       b       f         3.2.1.5.4.1       PFC Configuration       b       f         3.2.1.5.4.2       Maximum Plasma Heating Power       X       x         3.2.1.5.4.3       Temperature       X       x         3.2.1.5.5       Disruption Handling       X       x         3.2.1.5.6       Plasma Heating       X       x         3.2.1.5.6.1       Neutral Beam Heating       x       x
3.2.1.5.4       Power Handling       a         3.2.1.5.4.1       PFC Configuration       b       f         3.2.1.5.4.2       Maximum Plasma Heating Power       X         Maximum Component Surface       X         3.2.1.5.4.3       Temperature       X         3.2.1.5.5       Disruption Handling       X         3.2.1.5.6       Plasma Heating       X         3.2.1.5.6.1       Neutral Beam Heating       The following inspections and tests will be performed pri         First Plasma:       The beamline shall be mechanically installed on NCSX         All cabling and other connections shall be installed.       Beamline operating vacuum shall have been achieved.         Beamline cryopanels shall be leak-checked.       Power system refurbishment will be complete.         - A source shall be leak-checked.       Power system refurbishment will be complete.
3.2.1.5.4.1       PFC Configuration       b       f         3.2.1.5.4.2       Maximum Plasma Heating Power       X         Maximum Component Surface       X         3.2.1.5.4.3       Temperature       X         3.2.1.5.5       Disruption Handling       X         3.2.1.5.6       Plasma Heating       X         3.2.1.5.6.1       Neutral Beam Heating       The following inspections and tests will be performed pri First Plasma:         The beamline shall be mechanically installed on NCSX       All cabling and other connections shall be installed.         Beamline cryopanels shall be leak-checked.       Power system refurbishment will be complete.         - A source shall be leak-checked.       -
3.2.1.5.4.2       Maximum Plasma Heating Power       X         Maximum Component Surface       X         3.2.1.5.4.3       Temperature       X         3.2.1.5.5       Disruption Handling       X         3.2.1.5.6       Plasma Heating       X         3.2.1.5.6.1       Neutral Beam Heating       X         All cabling and other connections and tests will be performed pri       First Plasma:         - The beamline shall be mechanically installed on NCSX       All cabling and other connections shall be installed.         - Beamline operating vacuum shall have been achieved.       Beamline cryopanels shall be leak-checked.         - Power system refurbishment will be complete.       - A source shall be leak-checked.
Maximum Component Surface       X         3.2.1.5.4.3       Temperature       X         3.2.1.5.5       Disruption Handling       X         3.2.1.5.6       Plasma Heating       X         3.2.1.5.6.1       Neutral Beam Heating       The following inspections and tests will be performed pri First Plasma:         .       The beamline shall be mechanically installed on NCSX         .       All cabling and other connections shall be installed.         .       Beamline operating vacuum shall have been achieved.         .       Power system refurbishment will be complete.         .       A source shall be leak-checked.
3.2.1.5.4.3       Temperature       X         3.2.1.5.5       Disruption Handling       X         3.2.1.5.6       Plasma Heating       X         3.2.1.5.6.1       Neutral Beam Heating       The following inspections and tests will be performed pri First Plasma:         .       The beamline shall be mechanically installed on NCSX         .       All cabling and other connections shall be installed.         .       Beamline operating vacuum shall have been achieved.         .       Power system refurbishment will be complete.         .       A source shall be leak-checked.
3.2.1.5.5       Disruption Handling       X         3.2.1.5.6       Plasma Heating       Image: Constraint of the second secon
3.2.1.5.6       Plasma Heating         3.2.1.5.6.1       Neutral Beam Heating         3.2.1.5.6.1       Neutral Beam Heating         The following inspections and tests will be performed pri First Plasma: - The beamline shall be mechanically installed on NCSX - All cabling and other connections shall be installed. - Beamline operating vacuum shall have been achieved. - Beamline cryopanels shall be leak-checked. - Power system refurbishment will be complete. - A source shall be leak-checked.
3.2.1.5.6.1       Neutral Beam Heating       The following inspections and tests will be performed pri         First Plasma:       - The beamline shall be mechanically installed on NCSX         - All cabling and other connections shall be installed.       - Beamline operating vacuum shall have been achieved.         - Beamline cryopanels shall be leak-checked.       - Power system refurbishment will be complete.         - A source shall be leak-checked.       - A source shall be leak-checked.
The following inspections and tests will be performed pri First Plasma: - The beamline shall be mechanically installed on NCSX - All cabling and other connections shall be installed. - Beamline operating vacuum shall have been achieved. - Beamline cryopanels shall be leak-checked. - Power system refurbishment will be complete. - A source shall be leak-checked.
First Plasma: - The beamline shall be mechanically installed on NCSX - All cabling and other connections shall be installed. - Beamline operating vacuum shall have been achieved. - Beamline cryopanels shall be leak-checked. - Power system refurbishment will be complete. - A source shall be leak-checked.
3.2.1.5.6.1.1       Initial Neutral Beam Heating Complement       X       - Control systems shall be installed sufficient to begin subsystem testing.
Ultimate Neutral Beam Heating
3.2.1.5.6.1.2 Complement
3.2.1.5.6.2 Ion Cyclotron Heating (ICH)
3.2.1.5.6.3 Electron Cyclotron Heating (ECH) X
3.2.1.5.7 Plasma Fueling
3.2.1.5.7.1 Fuel Species X
3.2.1.5.7.2 Gas Injection a b c
3.2.1.5.7.2         Gas Injection         a         b         c           3.2.1.5.7.3         Pellet Injection         a         b         (b) is a future upgrade
3.2.1.5.7.2 Gas Injection a b c

## Key: X = Before First Plasma Y= After First Plasma

# Key: X = Before First Plasma Y= After First Plasma

Quality Conformance Matrix		Examination	Test	Demonstration	Analysis	Not Applicable	Remarks
3.2.1.5.9	Instrumentation, Control, and Data Acquisition			x			The following integrated tests are specified in the PEP: Integrated test of the safety interlock system. Integrated test of the timing and synchronization system. Integrated test of the power supply real time control system. Integrated test of the data acquisition system.
3.2.1.5.10	Pulse Repetition Rate			Х			
3.2.1.5.11	Discharge Termination						
3.2.1.5.11.1	Normal Termination			Х			
3.2.1.5.11.2	Abnormal Termination			Х			
3.2.1.6	Facility Shutdown			Х			
3.2.1.6.1	Coil Warm-up Timeline			Y			First few warmups should be closely monitored to assure that temperatures are tracking expected values and that no unanticipated thermal stresses are being imposed. Ultimate demonstration after First Plasma.
3.2.1.6.2	Vacuum Vessel Venting			Х			